Refaits 6770 8-6-91



Department of Mechanical Engineering • College Station, TX 77843-3123 • 409/845-1251 • FAX 409/845-3081 I.S. "Skip" Fletcher, Ph.D., P.E. "LSF0290@TAMSIGMA" Thomas A. Dietz Professor 409/845-7270

July 30, 1991

Ms. Betty Gaiser/1162 EF Contracting Officer Naval Weapons Support Center-Crane Crane, IN 47552-5011

Subject: Contract N00164-91-C-0043

Dear Ms. Gaiser:

In accordance with our Second Quarterly Report for the above-referenced contract, we are pleased to submit an Interim Report entitled, "A Review of Thermal Enhancement Coatings for Navy Standard Electronic Module Card Rails," (CHTL-6770-3). A copy of the Report has been forwarded to the cognizant Field Contract Administration Office.

Sincerely;

Leroy S. Fleth Leroy S. Fletcher

Enclosure

cc: Mr. Jerry Adams/NWSCC Mr. Martial W. Davoust/ONR-Austin Dr. G.P. Peterson/TAMU Ms. Kathy Ho/TAMRF

> DISTRIBUTION STU Approved for public relocion Distribution University

DTIC QUALITY INSPECTED A

A REVIEW OF THERMAL ENHANCEMENT COATINGS FOR NAVY STANDARD ELECTRONIC MODULE CARD RAILS

CHTL-6770-3

Contract No. N00164-91-C-0043

M.A. Lambert and L.S. Fletcher Conduction Heat Transfer Laboratory Department of Mechanical Engineering Texas A&M University College Station, TX 77843-3123

July 26, 1991

TABLE OF CONTENTS

1.0	INTROI	DUCTION	1			
2.0	LITERA 2.1	TURE REVIEW Metallic Coatings	3			
	2.2	Oxide and Anodized Coatings	13			
3.0	EVALU	ATION OF THEORETICAL PREDICTIONS	19			
4.0	0 SELECTION OF CANDIDATE COATING MATERIALS					
	4.1	Coating Materials	24			
	4.2	Coating Requirements for Maximum Contact Conductance	25			
	4.3	Survey of Metallic Elements	25			
	4.4	Coating Thicknesses	30			
5.0	5.0 PREDICTIONS OF CANDIDATE MATERIAL PERFORMANCE					
6.0	CONCL	USIONS	35			
RE	REFERENCES					

APPENDICES

- A. Theoretical/Analytical Equations for Predicting Contact Conductance
- B. Periodic Chart of the Elements

C. Published Experimental Data for Coatings

Accesi	on For				
DTIC	ounced]]]		
By Acg etc: Distribution/					
Availability Codes					
Dist	Avail and / or Special				
A-1					

ABSTRACT

The reliability of Navy standard electronic modules may be improved by decreasing overall module temperature. This may be accomplished by enhancing the thermal contact conductance at the interface between the module frame guide rib and the card rail to which the module is clamped. The surface irregularities resulting from the machining or extruding of the components cause the true contact area to be much less than the apparent contact area, increasing the contact resistance. Some metallic coatings, applied to the card rail, would deform easily under load and increase the contact area and associated conductance. This investigation evaluates possible coatings and determines those most suitable for use on card rails based upon predictions using existing theories for thermal contact conductance of coated junctions.

NOMENCLATURE

- Contact spot radius а
- Radius of heat flux channel b
- Thermal contact conductance h
- Η Hardness
- Thermal conductivity k
- Combined RMS absolute asperity slope $(m_1^2 + m_2^2)^{1/2}$ Mean number of microcontact spots per unit area m
- Ν
- Apparent contact pressure Ρ
- Thermal contact resistance R
- Coating thickness t
- Combined RMS roughness of both surfaces $(\sigma_1^2 + \sigma_2^2)^{1/2}$ σ
- Constriction factor φ

subscripts and superscripts

- Annular type contacts an
- Average av
- Per unit nominal area Α
- Contact С
- Filler f
- Filler-to-filler ff
- Joint j
- Metal Μ
- Metal-to-Filler Mf
- Metal-to-Metal MM
- Oxide 0
- Oxide-to-Oxide 00
- Substrate S
- Total t
- Refers to surfaces 1 and 2 1,2
- Refers to coating or coated contact ,
- Average

1.0 INTRODUCTION

Pursuant to the objective of enhancing the thermal contact conductance at the interface between the Navy Standard Electronic Module (SEM) formats D and E and their associated card rails, this review presents an evaluation of the most appropriate surface treatments and coating materials for the card rails.

One of the most effective means of controlling contact conductance is through the use of interstitial materials between components. The choice of interstitial material for a particular application is governed by such factors as contact pressure and temperature, environmental conditions, and of course, the degree to which it is desired to decrease or increase heat flow across the junction. Many thermal control materials are available, and Fletcher (1990) suggested that the materials could be divided into the following the major classifications:

(1) Greases and Oils

-

- (2) Metallic Foils and Screens
- (3) Composites and Cements
- (4) Surface Treatments

Fletcher (1990) also identified and discussed the principal advantages and disadvantages of each group of thermal control materials. Greases and oils, although easy to apply, may leak from the joint or evaporate with time. Metallic foils are effective for increasing contact conductance. However, improper insertion of the foil into the joint can cause wrinkling of the foil and actually decrease conductance. Also, disassembly and reassembly of junctions with interstitial foils is tedious, and they generally are not suitable for use in repeated contacts. Because of these shortcomings, thermal greases and foil inserts are excluded from further consideration. Composites and cements will also be excluded since they are generally used for thermal insulation.

Surface treatments are generally used to improve contact conductance or provide thermal control. Treatments such as metallic platings, coatings, and vapor deposited films are more permanent in nature than interstitial materials and may be suitable for applications involving repeated and/or sliding contact, depending upon coating properties and clearance. Therefore, surface treatments are the best choice for many applications.

A thorough search of the literature was undertaken to identify those investigations containing data and prediction techniques for the thermal conductance of coated contacts. Three types of coating materials were identified:

- (1) Metallic
- (2) Oxide
- (3) Anodic

In all studies, the coatings were deposited on a metallic substrate.

The results of each investigation are summarized in the literature review, and those materials suitable for thermal enhancement are identified.

2.0 LITERATURE REVIEW

There have been a number of investigations dealing with thermal contact conductance of coated surfaces. Some of these investigations do not provide enough information to permit evaluation. Those that provide complete experimental data are reviewed along with those theoretical/analytical studies which are suitable for coated surfaces.

The review is divided into two sections. The first deals with metallic coatings, the second with oxide and anodic films.

2.1 Metallic Coatings

Fried (1965) and Fried and Kelley (1965) described thermal contact conductance in the following manner. The contact heat transfer phenomenon, exclusive of the contribution of radiation, can be divided into the actual physical contact area determination and the contact heat transfer based on conduction across this actual area with and without an intervening film. The determination of the true contact area is very difficult because existing techniques are not suitable or practical. They stated that general elasticity and plasticity methods cannot be applied in most thermal contact problems for the following reasons:

- (1) The microscopic irregularities do not engage each other uniformly to form contacts but do so in groups as the large scale macroscopic areas engage each other. The possibility of sliding contact cannot be excluded from this consideration.
- (2) The contact intersection is neither purely elastic nor purely plastic but is elastoplastic or elastoviscous in character. Thus, as a load is applied there is a redistribution of pressure among the load-bearing asperities.
- (3) The surface layers, particularly when machined and polished or when exposed and oxidized, have properties different from the underlying material.

They suggested that similar classes of materials having similar types of work history and surface finish should permit the use of statistical or semi-empirical prediction methods. Thus, although the thermal performance of a particular set of interfaces may not be specifically predicted, a method may be developed to estimate the performance of a particular class of contacts provided the surfaces are well defined.

Fried and Kelley (1965) performed contact conductance experiments using 304 stainless steel specimens coated with vapor deposited aluminum and magnesium. One trial employed aluminum coatings on both contacting surfaces, which were 1.5 and 1.9 μ m (59 and 75 μ in.) in thickness. The surface roughnesses were 0.6 and 1.0 μ m (24 and 39 μ in.). For the other trial involving the magnesium coating, a 2 μ m (79 μ in.) thick film was applied to one surface only. The roughnesses of the coated and uncoated surfaces were 0.6 and 0.3 μ m (24 and 12 μ in.), respectively. Contact pressures ranged from approximately 0.4 to 8 MPa (58 to 1160 psi). Both interstitial materials enhanced the contact conductance over that of bare joints by as much as an order of magnitude at high contact pressures. For the aluminum-coated surfaces, the values of contact conductance obtained for descending loads were less than those for ascending loads.

The basic conclusions of the investigation applicable to coated contacts are:

- (1) There appears to be no significant effect of trapped or adsorbed gases on contact heat transfer.
- (2) Coarsely finished surfaces appear to permit more reliable contact heat transfer predictions and provide more reproducible test data. Conversely, very finely finished surfaces (such as optically polished surfaces) result in the least reproducibility and predictability.
- (3) The presence of soft metal platings substantially improves joint conductance.
- (4) Statistical prediction methods appear to hold promise for the thermal performance of inexactly defined surfaces.

Mal'kov and Dobashin (1969) investigated the resistance of Kh18N9T stainless steel specimens with electroplated coatings of silver, nickel, and copper. All coatings were 25 μ m

(0.001 in.) in thickness. Surface roughnesses varied from 0.85 to 1.9 μ m (33 to 75 μ in.), and deviations from true flatness ranged from 5 to 40 μ m (0.0002 to 0.0016 in.) Apparent contact pressures ranged from 0.48 to 5.6 MPa (70 to 810 psi), and testing was performed in a vacuum. The test temperature range was 250 to 550°C (482 to 1022°F).

They found that the microgeometry of the coating surface is determined to a large extent by the microgeometry of the underlying metal surface. Although the thickness of the coatings applied in this set of experiments was 12-15 times the height of the asperities, the surface characteristics of the coatings remained practically unchanged from those of the substrate for the case of the silver coating. The surfaces of the copper and nickel coatings were somewhat rougher and smoother, respectively, then their underlying stainless steel surface.

Mal'kov and Dobashin (1969) noted that for the given pressure range, the thermal contact resistances of the coated joints were reduced by factors of 2 to 10 from the value for the uncoated contact. The resistance of specimens that were lapped after being coated became negligibly small with increasing contact pressure. Increases in surface roughness and waviness resulted in increased resistance; however, the contact resistance was less affected by pressure for increasing waviness. Coated or uncoated lapped surfaces had lower resistance than unlapped surfaces, which they attributed to the decreased roughness and waviness. The coatings became decreasingly effective with increasing waviness.

Mikic and Carnasciali (1969) developed an analysis for the thermal contact resistance of an elemental heat channel (single contact). They argued that the analysis for an elemental heat channel can be used for evaluation of contact resistance for multiple contacts between nominally flat, rough surfaces or directly applied to calculation of macroscopic constriction resistance for wavy, smooth surfaces. They also-proposed that the thermal contact resistance is inversely proportional to the thermal conductivity of the material in the disturbed region, where isothermal surfaces are not parallel to the interface. They also stated that an increase in thermal conductivity in the vicinity of the contact points will reduce the contact resistance for a fixed geometry. They noted that highly conductive platings may significantly reduce the resistance. Platings may also be used to alter the geometry of the contact for a given interfacial load due to the generally different yield strengths of the plating and substrate.

Mikic and Carnasciali (1969) further suggested that the plating of only one contacting surface should have only a limited effect on the resistance since the entire constriction on the unplated side still has to take place in a low-conductivity material. When both surfaces are plated, the combined effects of the change of thermal conductivity in the constriction region and the change in geometry of the contact are fully realized, and the contact conductance is most improved.

Their model for predicting the ratio of the coated-to-uncoated contact conductance uses as input information three ratios: t/a, a/b, k_1/k_2 , where t is the plating thickness, a is the radius of the microcontact of the two plating asperities, b is the radius of the heat flux channel remote from the constriction, and k_1 and k_2 are the thermal conductivities of the plating and substrate materials, respectively. The resistance ratio for the coated-to-uncoated contacts (R/R) is reduced by increases in each of the three previously listed ratios.

An experimental verification of the theory was conducted by Mikic and Carnasciali (1969) using a macroscopic model of a single constriction. The plating and substrate materials were copper and 303 stainless steel, respectively. Cylinders of each material were soldered together to simulate perfect bonding of the plating to the substrate. Then a portion of each copper cylinder was turned to a smaller radius to simulate a constriction. Experiments using ratios of

a/b and t/a from 0.5 to 2.0 $(k_1/k_2=23.0)$ yielded reductions in the resistance ratio by a factor of 10 to 20. Their experimental results demonstrated close agreement with the theory. However, no information on surface topography was provided that would allow comparison of their results to those of other investigations.

O'Callaghan et al. (1981) present a theory which predicts the optimum thickness of a metallic coating for maximum thermal contact conductance. It assumes that ideal plastic deformation occurs at the interface of a rough and smooth surface. It further assumes that the material within intersections of the surfaces (i.e., parts of the asperities protruding into the coating) has no effect on the contact conductance. They indicate that if the filler material were fully ductile it would extrude from the asperity intersections into non-contact regions and result in greater values of thermal contact conductance than the theory suggests.

The following assumptions are intrinsic to their theory:

- (1) Surface asperities may be represented as right circular cones.
- (2) All microcontacts regions are annular.
- (3) The filler is of uniform thickness, so its presence does not alter the surface topographies.
- (4) As a result of assumptions (2) and (3), the contact configuration is comprised by basematerial-to-base-material circular microcontacts surrounded by concentric annuli of the filler material with additional circular microcontacts of the filler material alone.
- (5) Height distributions of the asperities may be described by Gaussian probability functions.
- (6) The effective thermal conductivity of a filler-to-filler contact, k_{ff} , is given by the harmonic mean of the filler and base metal conductivities.
- (7) The effective thermal conductivity of an annular contact is the arithmetic mean of the base metal and filler conductivities.

They suggested that if the filler is softer than the base materials, the real contact area will be increased for a given pressure compared to the same interface without filler. They also contend that the degree of improvement depends on the ratio of the conductivities of the filler and base materials, and the optimal filler thickness is expected to be of the order of the surface roughness.

O'Callaghan et al. (1981) conducted experiments using stainless steel (En58b) specimens with ion-deposited tin coatings ranging in thickness from approximately 3 to 106 μ m (0.00012 to 0.0042 in.) Their theoretical prediction exhibited fairly good agreement with the data.

Snaith et al. (1982) identified a general criterion for determining whether a filler material of suitable thickness will decrease contact resistance:

$$H_{M} k_{f} / H_{f} k_{M} > 1$$

where H_F and H_M are the hardnesses of the filler and substrate, and k_F and k_M are the thermal conductivities of the filler and substrate.

The optimal thickness is expected to occur when filler thickness, t, is on the order of the RMS surface roughness, σ . If t < σ , resistance is reduced because of the presence of additional solid flow channels through the filler. For t >> σ , the bulk resistance of the filler tends to exceed the reduction in constriction resistance afforded by the filler. The assumptions made in developing this theory are identical to those of O'Callaghan et al. (1981).

Antonetti and Yovanovich (1985) developed a thermomechanical model for predicting the contact conductance of a nominally flat, rough surface and a metallic-coated smooth surface. A correlation for bare joints, by Yovanovich (1982), was used as the basis for this coated contact theory. The major assumptions made in formulating this theory were:

- (1) Contacting surfaces are clean and in a vacuum. That is, gaseous conduction across the gaps is negligible. Radiation heat transfer is also negligible.
- (2) Contacting surfaces are microscopically rough but macroscopically flat and have Gaussian height distributions.

- . (3) When either of the contacting surfaces is coated with a soft metal, the real pressure between the surfaces is equal to that of the "effective" hardness of the layer-substrate combination.
 - (4) The real contact area consists of circular, isothermal, microcontact spots which are distributed uniformly over the apparent area. When a coating is present, the contact is also assumed to be a circular spot, but now residing on the top of the coating. In other words, penetration of the harder surfaces into the coating, which undoubtedly occurs to some extent, is ignored to simplify the subsequent thermal analysis.
 - (5) Contact between the coating and substrate is perfect. They cited an earlier investigation by Cecco and Yovanovich (1972) which states that the resistance of a perfect joint is about two orders of magnitude smaller than the constriction resistance of the pressed contact.
 - (6) A coated surface has the same surface characteristics as the underlying substrate.

Their predicted contact conductance is presented in a dimensionless form that is dependent on parameters which include: surface roughness and asperity slope, apparent pressure, microhardness of the rough surface and effective microhardness of the coated smooth surface, and the effective thermal conductivity of the joint (which involves the thermal conductivities of the two contacting materials and a constriction parameter correction factor for a coated joint). They stated that the effective microhardness of the coated surface must be determined experimentally for the particular coating-substrate combination in question. Experiments were performed on silver coated nickel specimens in contact with bare nickel specimens to verify the contact conductance theory. The applied contact pressure extended over the range of 500 to 3700 kPa (72 to 540 psi), and the mean interface temperature varied from 85 to 206°C (185 to 403°F). Their results for a pressure of 2000 kPa (290 psi) were nominally within 10% of their theoretical predictions of contact conductance. The contact conductance of the coated junction was as much as an order of magnitude greater than that of the bare junction. They also noted that for a given layer thickness, the enhancement increased for smoother surfaces. Kang et al: (1989) determined the degree to which lead, tin, and indium vapor-deposited coatings could increase the contact conductance of 6101-T6 aluminum interfaces. They used four thicknesses of each coating ranging from a few tenths of a μ m to a few μ m. All tests were conducted in a vacuum and over a nominal pressure range of 200 kPa (29 psi). Metrological information included average and RMS roughness, peak-to-valley height, average and RMS asperity slope, and average and maximum waviness height. They reported typical specimen surface measurements of approximately 0.7 μ m (28 μ in.) for RMS roughness, 0.08 for RMS asperity slope and 2.5 μ m (98 μ in.) for average waviness height. The average interface temperature for all tests was approximately 25°C (77°F).

They performed extensive Vickers microhardness tests of coated and uncoated specimens. Five readings at seven indenter loads were taken for each specimen tested. Coated surfaces exhibited a trend of increasing microhardness with increasing load (i.e., decreasing ratio of coating thickness to indenter penetration depth), which was also noted by Antonetti and Yovanovich (1985). Kang et al. developed analytical expressions for the effective microhardness of the three coating-substrate combinations that were analogous to that given by Antonetti and Yovanovich (1988) for a silver-coated nickel specimen. Kang et al. noted that the microhardness of the bare 6101-T6 aluminum samples increased slightly for greater indenter loads.

Kang et al. (1989) concluded that the optimal coating thicknesses were in the range of 2.0 to 3.0 μ m (79 to 118 μ in.) for indium, 1.5 to 2.5 μ m (59 to 98 μ in.) for lead, and 0.2 to 0.5 μ m (8 to 20 μ in.) for tin. They reported maximum coated-to-uncoated contact conductance ratios of approximately 7, 4, and 1.5 for indium, lead, and tin, respectively, and suggested that the coating hardness appears to be the most significant factor in ranking the effectiveness of a coating. They further noted that the conductance enhancement provided by a coating of a given thickness was greatest at low contact pressures, decreasing significantly with increases in contact pressure.

They reasoned that as pressure was initially increased, the growth in contact area of the coated joints was much greater than for the bare joints due to the softness of the coating. They went on to state that as the pressure was steadily increased, the rapid growth in contact area was reduced by the contact between substrate asperities which had penetrated the coating material. Finally, they concluded that the reduction in the contact area growth rate resulted in a reduction in the thermal contact conductance enhancement. Kang et al. (1989) also observed that the optimal coating thickness decreased as pressure was increased.

Chung et al. (1990) studied the effects on contact conductance of ion-vapor-deposited coatings of aluminum, lead, and indium on 6061-T6 aluminum. They employed two coating thicknesses, 25.4 and 50.8 μ m (0.001 and 0.002 in.), and two surface roughnesses, 1.6 and 3.2 μ m (63 and 126 μ in.). Two-surface coatings (i.e., both surfaces of a contact pair were coated with a combined coating thickness of 25.4 or 50.8 μ m) were also investigated. Thermal conductance enhancement varied from 0 to 500 percent of the uncoated value depending on the surface characteristics. Four nominal contact pressures from 100 to 500 kPa (14 to 72 psi) were used.

The ratios of coated-to-uncoated contact conductance for the rougher substrates showed greater improvements. This was attributed to the fact that a rougher substrate will penetrate a soft coating more deeply, thereby increasing contact area and contact conductance. For the smaller substrate roughness, 1.6 μ m (63 μ in.), pressure had little effect on the conductance ratio with the exception that the thicker indium coating exhibited a peak conductance at 175 kPa (25 psi). Also, for aluminum and lead coatings, the coated-to-uncoated conductance ratios for the two coating thicknesses showed little difference, while the conductance ratios for indium increased slightly for the thicker coating.

For the larger substrate roughness, $3.2 \,\mu m$ (126 $\mu in.$), the conductance ratio increased with pressure for aluminum and lead coatings and was generally slightly less for the thicker coating than for the thinner coating. Interfaces coated with indium exhibited an opposite trend of higher conductance ratios for the thicker coating, and contact pressures between 175 and 275 kPa (25 and 40 psi) provided the greatest enhancement of conductance. Also, for a given coating material and total coating thickness, two-surface coatings generally provided greater increases in contact conductance than one-surface coatings.

The enhancement of thermal contact conductance varied from 150 to 500, 0 to 250, and 0 to 100 percent increases for indium, aluminum, and lead, respectively. Chung et al. (1990) observed that the differences between the conductance ratios of two-surface and one-surface coatings were dependent on the coating material involved. Lead coatings showed no significant differences, whereas two-surface coatings of aluminum and indium displayed significantly increased conductance over one surface values. They noted that in general, for a given coating thickness the enhancement of conductance increases with surface roughness, provided the thickness of the coating is many times greater than the value of surface roughness.

Chung et al. (1991) examined pure copper and copper-carbon mixtures (transitional buffering interfaces, TBI) applied to both contacting surfaces of 6061-T651 Al. They employed four aluminum surface roughnesses ranging from 0.17 μ m to 3.55 μ m (6.8 to 142 μ in.). Two coating thicknesses, 0.19 and 0.24 μ m (7 and 9 μ in.) for the copper coatings and 0.25 and 0.45 μ m (10 and 18 μ in.) for the Cu/C coatings, were tested for each of the four surface roughnesses. The coating process involves plasma-enhanced deposition onto cold surfaces of either conducting (metallic) or non-conducting (nonmetallic) base material. They claimed that TBI coatings provide excellent contact conductance and long life under repeated loads.

Pure copper yielded contact conductance values 1.09 to 1.31 times those for copper and carbon phase mixtures over a pressure range of 125 to 500 kPa (18 to 72 psi). They stated that pure copper coating is more thermally conductive than a Cu/C coating because of the low thermal conductivity and high hardness of carbon.

They assumed that load cycling increased contact conductance by successively plastically deforming the surfaces. There were also hysteresis effects, i.e., the unloading conductance was greater than loading conductance for a given pressure. Blasted rough, bare surfaces had higher conductances than polished surfaces by a factor of from 1.3 to 2.6 due to the larger area of contact spots of the former. They also noted that the most significant improvement in conductance, as a result of the application of coatings, was obtained for turned surfaces (as opposed to polished or blasted surfaces) for which the root-mean-square (rms) roughness was approximately equal to the coating thickness. Coating thicknesses beyond this led to decreased conductance. Also, coatings much thinner than the surface roughness values did not improve conductance.

2.2 Oxide and Anodized Coatings

Yip (1974) developed a prediction for the contact resistance of oxidized metal surfaces. These oxides form as a result of exposure to the atmosphere, fresh or sea-water, or soil. He stated that oxides are much less ductile than most light metals, and their presence decreases the actual contact area. He suggested that contact conductance is further reduced by the generally poor thermal conductivity of oxides.

The expression for estimating contact resistance includes as variables: surface roughness, asperity slope, nondimensional oxide thickness, the ratios of apparent pressure to substrate metal hardness and oxide-to-metal hardness, and the thermal conductivities of the metal and its oxide.

The theory predicts a one-hundred fold increase in contact resistance for aluminum with a total oxide thickness approximately equal to the surface roughness for a non-dimensional stress of 10^{-3} , which is the ratio of the apparent pressure to the metal hardness.

Yip noted that the oxidation film thickness of aluminum alloys varies from 0.003 to 0.3 μ m (0.12 to 12 μ in.) when such metals are exposed to air at various humidities. Magnesium and its alloys exhibit a build-up of magnesium hydroxide at a rate of 0.01 μ m (0.4 μ in.) per year when exposed to humid air. He stated that the roughness of machined surfaces may range from 0.025 to 6.5 μ m (0.98 to 256 μ in.). Thus, it was suggested that the contact resistance of aluminum alloys may vary by a factor of 100 over the stated range of surface finishes and severity of oxidation.

He conducted experiments using specimens of 6061-T6 aluminum alloy with one of two rms average surface roughnesses, 1.5 and 6.6 μ m (59 and 260 μ in.), and an assumed oxide thickness of 0.075 μ m (3 μ in.). Theory and data agreed quite well for this assumed oxide thickness. The contact resistance increased by a factor of nine for a pair of smoother surfaces with roughnesses of 1.5 μ m (59 μ in.) and by a factor of two for a pair of surfaces with roughnesses of 6.6 μ m (260 μ in.). Yip's theory could not be explicitly proven accurate due to the lack of knowledge of actual oxide film thicknesses.

Mian et al. (1979) examined the contact resistance of oxide films on samples of mild steel (EN3B). They tested specimens that were lapped flat then sandblasted to a roughness of 0.08 μ m (3.3 μ in.). One contacting surface was oxidized to obtain a film thickness of 0.35 μ m (14 μ n.). They employed a form of the Arrenhius equation was used to estimate the growth of oxide films for various temperatures and oxidation periods.

The data, when plotted with additional data for different oxidized EN3B specimens obtained from colleagues (Al-Astrabadi et al., 1980), indicated that the thermal contact resistance

decreased with increasing load and surface roughness. Mian et al. suggested that the common slope of the linear-resistance-versus-pressure traces was suggested to be the result of ideal plastic deformation of the surface irregularities. They also attributed the observance of a slight hysteresis upon unloading to plastic deformation. The contact resistance was doubled when the ratio of total oxide film-thickness-to-surface-roughness was approximately equal to four, but increases in the ratio beyond this value did not significantly increase the contact resistance. The film thickness, rather than the roughness, was the dominant variable affecting the resistance. They correlated the entire population of data and demonstrated that it agreed reasonably well with Yip's theory.

Mian et al. (1979) identified factors that affect contact resistance. These include constriction and dilation of heat flow in oxide films, the shapes of the microcontacts as dictated by the history of the surfaces, the isotropy of the surface roughness, and the degree of waviness. They also proposed that knowledge of the manner in which oxide films rupture, the local yielding regions, and the fracture stresses are needed for a comprehensive understanding of the behavior of oxidized contacts. The authors contend that although the film does fracture, it is still present and probably affects the contact resistance.

Al-Astrabadi, et al. (1980) developed a theoretical prediction for the contact resistance of oxidized, nominally flat, randomly rough metallic surfaces. The assumptions regarding the nature of the microcontacts are analogous to those later described by O'Callaghan, et al. (1981). The filler material for the former case was an oxide film, whereas in the latter investigation it was replaced by a metallic coating. Al-Astrabadi et al. noted that an oxide is, in general, harder and less ductile than its parent metal. Thus, they concluded that the formation of oxides tends to reduce the true metal-to-metal contact for freshly assembled joints, resulting in increased thermal contact resistance.

Al-Astrabadi et al. (1980) contended that the resistance of a metal-to-metal joint between clean surfaces, assembled in a vacuum and under constant heat flux and loading, should decrease when exposed to an oxidizing atmosphere. This is due to the growth of oxide around the contacting asperities leading to enhanced annular oxide-to-oxide contacts as well as additional newly formed oxide-to-oxide bridges. However, they also stated that resistance is seen to increase with oxide film growth because of several factors.

- (1) The contact is seldom subjected to a constant load and heat flux.
- (2) Such mechanical and thermal fluctuations result in intermittent contact behavior allowing the growth of oxides to disrupt the metallic contact bridges.
- (3) The accumulation of oxide in the non-contact regions could force the surfaces apart, breaking the metallic bridges.
- (4) Oxide and contaminant formation induces passive transient behavior, encouraging factors(2) and (3) above.

They conducted experiments to verify the theory using mild steel (EN3B) specimens with surface roughnesses ranging from approximately 0.12 to 2.0 μ m (4.7 to 79 μ in.), asperity slopes between 0.04 and 0.19 radians, and oxide film thicknesses of 0.055 to 0.118 μ m (2.2 to 4.6 μ in.). They noted that oxidation of the surfaces had a minimal effect on their topography, and the distribution of asperity heights was nearly Gaussian. However, they cautioned that this observation was only valid for thin oxide films. Heavily oxidized surfaces exhibited a five-fold increase in roughness over the unoxidized condition and displayed skewed height distributions. The theory agreed reasonably well with the data for the range of surface parameters examined.

The authors further noted that when coated surfaces are pressed together, the contact is different from bare surfaces under identical conditions. They stated that the following three ratios influence the contact resistance: the ratio of coating to substrate hardness, the ratio of coating to substrate thermal conductivity, and the ratio of coating thickness to surface roughness. They postulated that if the coating is much thicker than the roughness, then the resistance increases with increasing coating thickness. Provided that the coating thickness is on the order of or less than the roughness, the resistance will decrease if the coating is much softer than the substrate.

Peterson and Fletcher (1991) conducted an experimental investigation of the thermal contact conductance of anodized coatings. Seven anodized samples of 6061-T6 aluminum with coating thicknesses ranging from 60.9 to 163.8 μ m (0.0024 to 0.0065 in.) were tested in contact with a single bare sample. Surface roughness ranged from 0.30 to 5.33 μ m (12 to 210 μ in.), while asperity slopes varied from 0.08 to 0.25. All surfaces were flat to within approximately 1 μ m (39 μ in.). Both the overall joint conductance between the anodized and bare surface and the bulk conductance of the anodic coating increased with increasing contact pressure and decreased with increasing coating thickness.

The authors described the basic methods in applying anodic surface treatments and other types of coatings. Anodized coatings result from an oxidation process at the surface of a material. Although anodized surfaces are mechanically similar to electroplated or vapor-deposited coatings, the anodized coatings are created by chemical conversion of the outer layers of a material, whereas the other two processes involve the bonding of a substance to the substrate. The oxidized surface is an integral part of the material and has excellent adherence.

Their conclusions indicated that for very smooth, untreated surfaces, slight increases in the roughness cause moderate increases in contact conductance. The overall joint conductance was more sensitive to variations in pressure for the thinner coatings than for the thicker coatings. They explained this as being due to variations in the effective microhardness of the surfaces. They proposed that for very thin anodized layers, the effective microhardness of the interface results from a combination of the uncoated aluminum surface, the relatively hard oxide, and the aluminum substrate. As the thickness of the anodized surface increases, the uncoated surface asperities do not penetrate the anodized coating, and the effective microhardness results only form a combination of the uncoated aluminum surface and the anodized surface.

Using their experimental data, the authors developed an empirical, dimensionless expression that related the overall joint conductance to the coating thickness, the surface roughness, the interfacial pressure, and the thermophysical properties of the aluminum substrate.

3.0: EVALUATION OF THEORETICAL PREDICTIONS

This section is devoted to describing how the various theories for predicting contact conductance compare to the available data. The prediction (or predictions) that best models the existing data is used to determine the level of contact conductance enhancement afforded by the potential rail coating materials. These materials are listed in Table 1, and discussed in more detail in this section. First, the adequacy of the prediction technique must be ascertained.

The descriptions and comparisons of the various theories and data given below refer frequently to Figs. 1a and 1b. These figures illustrate four prediction techniques and data from ten investigations on the thermal contact conductance of metallic junctions with metallic or oxide (including anodic) interstitial coatings. All data and prediction technique included in Figs. 1a and 1b have been reduced to the same dimensionless groupings as those employed by Antonetti and Yovanovich (1985), since this prediction technique proved to be most useful for reducing all of the information to an equivalent form. It should be noted that all the prediction techniques incorporate Bessel functions into the computation of constriction factors for characterizing the contact. These often involve simultaneous solution of several algebraic or integral equations. However, the analysis in Antonetti and Yovanovich (1988) also contains a table of constriction factors that are listed in terms of topographical (i.e., metrological), thermophysical, and loading information on the contact that is readily, though tediously, calculable. This later work illustrates the application of their 1985 investigation to different coatings and substrates. The predictions of Antonetti and Yovanovich (1985) and O'Callaghan et al. (1981) explicitly apply to metallic coatings, whereas those of Al-Astrabadi et al. (1980) and Yip (1974) are intended for oxide films.

The predictive technique in Antonetti and Yovanovich (1985) utilizes the mean asperity slope, m, a surface parameter not found in all ten investigations on contact conductance from

which data has been extracted. However, Antonetti and Yovanovich (1985, 1988), Kang et al. (1989), Al-Astrabadi et al. (1980), Peterson and Fletcher (1990), Yip (1974), and O'Callagahan et al. (1981) did provide measurements of mean asperity slope. Analysis of the metrological information revealed a relationship between RMS asperity slope and RMS roughness, which is described by the expression:

$$m \sim \sqrt{\frac{\sigma}{100}}$$

This relationship was used in reducing data from those investigations lacking asperity slope measurements to the nondimensional form given by Antonetti and Yovanovich (1985). This expression is accurate to within approximately $\pm 50\%$ for all but the data of O'Callaghan et al. (1981). The measurement asperity slopes of O'Callaghan et al. are considerably smaller than those predicted by the slope equation.

Translation of the other three prediction techniques, those of O'Callaghan et al. (1981), Al-Astrabadi et al. (1980), and Yip (1974), to the nondimensional form found in Antonetti and Yovanovich (1985), resulted in a family or group of parallel lines for each theory. Since the prediction lines for each theory were not widely separated, the average trace of each group is plotted in the appropriate figure (1a or 1b). As evident in both figures, the predictions lie quite closely to each other, and they tend to define an upper bound to the data. Also, as expected, each theory closely approximates its associated data. The predictive expressions from the four theories described above, as well as the expression for anodized surfaces from Peterson and Fletcher (1990), are listed in Appendix A.

The two theories that apply to metallic coatings, those of O'Callaghan et al. (1981) and Antonetti and Yovanovich (1985), are almost precisely colinear, although they extend over the low and high pressure regimes, respectively. Although the two theories for metallic coatings are

accurate for their corresponding data, they both perform rather poorly for the majority of the data on such contacts extracted from other investigations: Chung et al. (1991), Fried and Kelley (1965), Kang (1989), and Mal'kov and Dobashin (1969). The two predictions overestimate the contact conductance by as much as a factor of 100. These discrepancies may be due in part to the fact that all of the theories implicitly assume that the contacting surfaces are perfectly flat, so they cannot account for the significant flatness deviations (waviness) reported in some of the other studies. As the waviness of a surface increases, its contact area decreases, thereby reducing the contact conductance. For example, specimens used by Mal'kov and Dobashin (1969) exhibited surface waviness measurements from 5 to as great as 40 μ m (0.0002 to 0.0016 in.). This last value is approximately 20 times larger than its associated roughness. This wide range of waviness may be the cause of the considerable scatter of the results from their experiments seen in Fig. 1a. Fried and Kelley (1965) listed the maximum flatness deviation as 3.8 μ m (150 µin.). Although, this value is approximately four times the associated rms surface roughness, it is unlikely that this alone could have caused the very low dimensionless conductances (nearly two orders of magnitude less than the theories) calculated for this set of experiments. These large variations may suggest the existence of some important and, as of yet, unrecognized parameter. Chung et al. (1991) did not provide explicit values of waviness. However, some of the specimens they studied had turned surfaces, which usually exhibit significant deviations from flatness. Kang (1989) listed waviness heights typically equal to 2.5 µm (98 µin.) for the turned aluminum surfaces examined.

The anodized 6101-T6 aluminum and nickel plated C11000 copper SEM frames have specified flatness deviations of 50 and 250 μ m (0.002 and 0.010 in.), respectively. Thus, for the reasons described above, the contact conductance of these frames to the A356-T61 aluminum card rails should be significantly less than that predicted by the theory of Antonetti and Yovanovich (1985)

Since the theory in Antonetti and Yovanovich (1985) is presented in the most tractable form for calculations, it is used here to estimate the contact conductance provided by the possible coating materials listed in Table 1. This prediction describes the upper bound of contact conductance, since it was developed for flat surfaces. The estimated contact conductances of coated contacts determined using this prediction, will not be representative of real machined or ground surfaces (which exhibit considerable waviness) unless corrected by some appropriate factor to account for this waviness. No theory has been proven adequate for quantitatively evaluating the effect of surface waviness. Consequently, the estimated ratios of coated to uncoated contact conductance listed in Table 2 and illustrated in Fig. 2 are no doubt inflated. The value of these computed ratios is in the fact that they allow the various candidate coatings to be qualitatively compared and ranked in order of expected thermal performance.

The predictions for contacts containing interstitial oxide films, shown in Fig. 1b, although accurate for oxide films, somewhat overestimate the contact conductance of junctions with anodic coatings. Peterson and Fletcher (1991) conducted experiments on 6061-T6 aluminum with anodized coating thicknesses varying from 61 to 164 μ m (0.0024 to 0.0065 inch) and surface roughnesses from 0.3 to 5.3 μ m (12 to 212 μ in.) in contact with bare 6061-T6. The specimens had flatness deviations on the order of 1 μ m (39 μ in.) or less. Since the descriptions of the 6101-T6 SEM frames do not stipulate the exact anodized coating thickness, it is assumed to be 50 μ m (0.002 inch) as instructed in MIL-A-8625E (1988). The roughness of the aluminum 6101-T6 frames is specified to be 0.6 μ m (24 μ in.), and the maximum allowable flatness deviation is 50 μ m (0.002 in.). Thus, apart from surface flatness, these two contact systems are quite similar since the thermal conductivities and hardnesses of the aluminum alloys considered do not differ greatly. As with metallic contacts, increased deviations from flatness cause reductions in the

contact area and, consequently, the contact conductance. Therefore, the values of conductance obtained in Peterson and Fletcher (1991) should be greater than those of the presently employed anodized 6101-T6 to uncoated A356-T61 junctions.

4.0-:SELECTION OF CANDIDATE COATING MATERIALS

A number of materials have been used as coatings for controlling the thermal contact conductance of pressed contacts. This section describes in detail the selection of those coatings that may best improve the contact conductance of the SEM/card rail interface.

4.1 Coating Materials

As explained by Fletcher (1990), of the four basic types of interstitial materials, only surface treatments and coatings are deemed suitable for microelectronic applications. Coatings may be polymeric, ceramic, composite, metallic, nonmetallic, or oxidic in nature. Although polymeric coatings are typically resistant to deterioration in a marine environment, and may improve conductance if impregnated with metal particles, they generally only provide moderate enhancement. Ceramics and oxides are almost invariably insulative. Composites generally exhibit the same performance as polymers, as they are usually comprised mainly of polymeric resins. Metallic coatings are typically the most highly thermally conductive materials and may afford the greatest improvement in thermal contact conductance. Thus, consideration of possible coating materials is limited primarily to metals.

One noteworthy, potentially highly conductive nonmetallic coating material is carbon. It exists in two main allotropic forms, graphite and diamond. Graphite has a thermal conductivity of 1950 W/m-K in directions parallel to the layers of atoms although its thermal conductivity is only 5.7 w/mK perpendicular to the layers. This is approximately five times that of silver, the most conductive metal. However, graphite is probably too soft and brittle to remain intact in sliding or clamped contacts. Chemical vapor-deposited (CVD) diamond coatings are also highly conductive (1000-1300 W/m-K), as determined by Herb et al. (1989). Diamond is extremely

hard and impervious to environmental corrosion. Diamond also has a high thermal conductivity, and is extremely effective as an electrical insulator. At present the effect of CVD diamond coatings on contact conductance is unknown, and additional research is necessary to determine the performance of diamond films for both static and sliding thermal enhancement applications.

4.2 Coating Requirements for Maximum Contact Conductance

Criteria that are considered most important for enhancement of the thermal contact conductance of the frame-rail interface have been evaluated. Some investigators, such as O'Callaghan et al. (1981) and Snaith et al. (1982), suggest that the ideal coating material possesses a large ratio of thermal conductivity to hardness. They contend that coatings of low hardness deform readily under load, flow around the asperities, and thereby increase the contact area. High values of thermal conductivity tend to alleviate the constriction resistance through the reduced areas of the microcontacts, and this coating property is considered by Mikic and Carnasciali (1969) to be highly important. A number of metals with high ratios of thermal conductivity-to-hardness are listed in Table 1 for comparison.

4.3 Survey of Metallic Elements

Since metals are the type of coating material thought to be most appropriate for SEM/card rail applications, an assay of all metallic elements has been made to justify the selection of those elements considered as candidate coatings. Those selected are listed in Tables 1 and 2. Properties of the metals were taken from a number of sources, including: Tabor (1951), the Metals Handbook (1990), Touloukian and Ho (1972, 1976), Hultgren et al. (1973), Westbrook and Conrad (1973), Ho (1974), Weast, (ed) (1974), Smith (1981), Richman (1967), Brick et al. (1971), and Flinn and Trojan (1981). A summary of the performance characteristics is provided

in Table 2.

The elements in the periodic table, shown in Appendix B, are arranged according to their electronic configurations, which give rise to many of their properties. Therefore, it would seem logical to sort through the metals group by group, a group being those elements with similar valence or outer shell electron configurations, to determine those which best suit the requirements of a conductance-enhancing coating.

The first two columns of the periodic table, except for hydrogen, contain the alkali metals with valence numbers of one or two. These are typically highly reactive. All but two, beryllium and magnesium, may be summarily excluded from consideration because they are either poisonous, radioactive, available in insufficient supply, or react vigorously or even explosively when exposed to moisture or ignite spontaneously when exposed to air. Beryllium, although it is employed where lightness and stiffness are needed and does resist oxidation in air, is toxic. Although Beryllium has a high thermal conductivity, it is toxic and is very hard with a Brinell Hardness (BHN) of 97. Magnesium tarnishes slightly when exposed to air and ignites when heated. This combination of disadvantages makes magnesium an unlikely choice. However, since it is used in a number of applications, it is included in the group of candidate coatings.

To the right of the alkali metals are the rare-earth or lanthanide series of metals, and below them are the actinide series. Lanthanum, the first of the rare-earths, oxidizes rapidly in air and exhibits low to moderate toxicity. Next is cerium, which oxidizes very readily in moist air and may ignite if scratched. Praseodymium, though somewhat more stable than lanthanium or cerium, develops a green oxide coating in air which spalls off, thereby exposing more of the metal. Neodymium quickly tarnishes in air, its oxide also spalls off, and it has low to moderate acute toxicity. Promethium is extremely rare, it does not exist naturally on earth, and must be synthesized at great expense. Samarium, though reasonably stable in air at room temperature, ignites when heated above 150°C and is also possibly toxic. Europium is about as hard as lead, is the most reactive metal of this series, and quickly oxidizes in air. As with other rare-earth metals, except for lanthanium, europium ignites in air at 150 to 180°C. Gadolinium is relatively stable in dry air, but in moist air it tarnishes with the formation of a loosely adhering oxide film that spalls off. Terbium is reasonably stable in air and is soft and ductile, however, it is very expensive and possibly toxic. Dysprosium is soft and relatively stable in air at room temperature, rapidly oxidizes in moist air and at elevated temperature, and possibly exhibits low toxicity. Erbium is reasonably stable in air but will oxidize when exposed to moisture. It is expensive and has low to moderately acute toxicity. Ytterbium, while fairly stable, oxidizes in air and moisture and has low acute toxicity. The last rare-earth, lutetium, is stable in air but very expensive and also has low toxicity.

Below the rare-earth metals are the actinides. The first in this series, actinium, is highly radioactive. Its chemical behavior is similar to the rare-earths, particularly lanthanum. Thorium is soft and very ductile, however, it is a radiation hazard and should be stored and handled in areas with good ventilation. Protactinium is a dangerous toxin and is very expensive. Uranium and its compounds are highly toxic, both chemically and radiologically. Neptunium, found only in trace quantities in nature, is chemically reactive and very expensive. The remainder of the transuranium elements (those to the right of uranium) are radiological poisons. They are absorbed by bone marrow, and trace quantities may destroy the body's ability to generate blood corpuscles.

To the right of the rare-earth metals in the periodic table are the ten columns of transition elements. The subject of their applicability is discussed in more detail, as they are not radioactive and are generally less reactive than the alkali or rare-earth metals.

In the first column of the ten columns of transition elements are scandium and yttrium. Their properties resemble those of the rare-earth elements. Scandium is relatively soft, oxidizes slightly in air, is expensive, and may also be toxic. Yttrium is less expensive than scandium and is relatively stable in air in bulk form.

The second column is composed of titanium, zirconium, and hafnium. All have excellent resistance to seawater corrosion. Titanium is too hard (BHN 200) to be useful as a coating.

Vanadium, niobium, and tantalum comprise the third column. Vanadium is moderately hard and ductile and resistant to salt water. Niobium is slightly harder but still ductile. It begins to oxidize above 200 C. Tantalum is almost completely inert below 150°C and is relatively hard (BHN 60). All are considered because of their desirable low reactivity.

Chromium, the uppermost element of the fourth column is extremely resistant to corrosion and is usually quite hard, even in the annealed state (BHN 100). It is included in consideration because it is widely used as a protective plating. Molybdenum and tungsten are too hard and brittle for this application.

As for the fifth column, manganese is extremely hard (BHN 300) and brittle, so it not considered. Technetium does not naturally exist, is very expensive, and is radioactive. Rhenium, is corrosion and wear resistant, but too hard to be useful.

The top element in the sixth column, iron, is moderately hard (BHN 70) and oxidizes rapidly in moist air. The next two, ruthenium and osmium, are extremely hard (BHN 220 and 400, respectively) and are stable in air at room temperature. The oxides of the latter two are highly toxic and unsuitable for microelectronic interfaces.

The seventh column of the transition elements contains cobalt, rhodium, and iridium. All are extremely oxidation resistant. Cobalt is moderately hard (BHN 48) in the annealed state and

may be worth consideration. Rhodium is very hard (BHN 135), but, since it is sometimes employed as a plating, it is listed as a candidate material. Iridium is even harder (BHN 170) than rhodium, so it is unlikely to improve conductance.

In the eighth column are nickel, palladium, and platinum. All are noble metals and are used to differing extents as platings. Thus, all are evaluated in terms of their applicability to this project. Nickel is fairly hard (BHN 75). Palladium and platinum are markedly softer but expensive.

The ninth column is occupied by copper, silver, and gold. These are the most highly conductive metals and are relatively soft, making them attractive possibilities. Copper and silver tarnish slightly in air. Gold has the unique property among the metals that its oxide is unstable. Therefore, gold surfaces will remain bright indefinitely.

Zinc, cadmium, and mercury comprise the tenth and last column of the transition metals. Cadmium is soft and also toxic but used extensively in electroplating. Thus, it is considered. Mercury is, of course, highly poisonous and liquid at room temperature, making it unsuitable. Zinc is fairly soft but highly reactive. It is frequently used as a plating, so it is included in the present analysis.

To the right of the transition metals are those elements that become increasingly more like metalloids and nonmetals with increasing proximity to the noble gases. Beginning with the column under boron, the first metal encountered is aluminum, which is quite soft and highly conductive, making it worthy of attention. However, aluminum does form an oxide scale in air. Gallium, next below aluminum, has an insufficiently high melting point, 30°C (86°F). Indium is extremely soft and more resistant to atmospheric corrosion than silver. There is evidence that it has a low level of toxicity, but this is considered minor and is effectively dealt with by exercising normal hygiene. Thallium, at the bottom of this column, is very soft. It also forms

a heavy oxide if left in air and is poisonous, even when only in contact with the skin.

The first metalloid below carbon is germanium. It is crystalline and brittle, therefore unsuitable. Tin is next. It is very soft and resistant to sea water. Last in this column is lead, which is also very soft and resistant to corrosion. A lead carbonate-hydroxide forms on lead in the presence of moisture and carbon dioxide, resulting in a white deposit on the surface. Care must be exercised in handling lead as it is a cumulative poison.

Arsenic is the first metalloid below nitrogen. It is very hard (BHN 147) and brittle, tarnishes in air, and is poisonous. Underneath arsenic is antimony, which is an extremely brittle metal with a flaky, crystalline texture. It does not react with air at room temperature, but burns when heated. Antimony is also toxic. At the bottom this column is bismuth. It is quite soft, though poorly conductive. It burns when heated sufficiently in air. Since it is so soft (BHN 11) it is evaluated as a coating, despite its disadvantages.

Below oxygen and sulfur is selenium, a nonmetal which resembles sulfur in its various forms and compounds and has a very low thermal conductivity. Although elemental selenium is considered almost nontoxic, hydrogen selenide is extremely poisonous. Tellurium is a semiconductor and is brittle and probably toxic. Polonium is dangerously radioactive.

In all, 20 metallic elements were chosen for evaluation of their ability to enhance the contact conductance of the frame-card rail interface. Their selection was based on loosely defined requirements of low hardness, high thermal conductivity, excellent corrosion resistance, or a combination of these properties.

4.4 Coating Thicknesses

Reasons for the specification of coating thicknesses for the candidate metals listed in Table 2 are described below. Coating thicknesses which are of the same order as the combined rms surface roughness have been demonstrated to be optimal by O'Callaghan (1981). Existing data on the various coating materials was utilized in selecting the precise thickness of each coating to be used in calculations of contact conductance. Kang (1989) demonstrated that the optimal coating thicknesses for indium, lead, and tin on substrates of 6061-T6 aluminum were 2.5, 2.0, and 0.5 μ m (98, 79, and 20 μ in.), respectively. The surfaces roughness of the nominally flat specimens investigated by Kang (1989) was typically 0.7 µm (28 µin.), which is nearly equal to that specified for the 6101-T6 aluminum and copper frames. Since a surface roughness of 0.6 µm (24 µin.) is prescribed for the frame materials, it is here assumed that this would be an appropriate roughness for the A356-T61 aluminum card rails. Thus, because the optimal coating thickness is assumed to be dependent on the roughness, and because the roughness of the specimens used by Kang is approximately equal to that assumed to be appropriate for the rails, the optimal thicknesses of the indium and lead coatings given above are used for the present purposes. A tin coating thickness of 2 µm (79µin.) is used instead of 0.5 µm (20µin.) to maintain uniformity. It seems odd that the optimal tin coating thickness should be greatly different from the optimal lead coating thickness, since they have essentially the same hardness.

Antonetti and Yovanovich (1988) reported the ideal thickness of a silver coating on an aluminum substrate to be approximately 20 μ m (0.0008 in.) for a combined rms roughness for both surfaces of 4 μ m (157 μ in.), yielding a ratio of coating thickness-to-roughness of five. Thus, for a combined rms roughness of 0.85 μ m (33 μ in.) for the frame-rail combination, the optimal silver coating thickness should be approximately 4 μ m (157 μ in.). The same coating thickness is employed in calculations involving materials that are similar in hardness (BHN from 25 to 40 kg/mm²) to silver (e.g., gold, copper, magnesium, etc.). Aluminum and bismuth are intermediate in hardness to the very soft coatings (indium, tin, and lead) and the group containing silver, gold, copper, magnesium, etc. Thus, an intermediate value of thickness, 3 μ m
(120 µin.), is used in computations for the aluminum and bismuth coatings. The remaining metals in Table 1 with hardness values greater than BHN 40 are assigned coating thicknesses of 5 µm (197 µin.) for calculations of contact conductance, since it appears that the optimal coating thickness increases with increasing hardness.

5.0 PREDICTIONS OF CANDIDATE MATERIAL PERFORMANCE

The performance of the various coating materials has been evaluated in terms of their applications to SEM card rails. Note that Table 2 lists two coated-to-uncoated contact conductance ratios for each material. These are for the minimum and maximum contact pressures, 173 and 865 kPa (25 and 125 psi), respectively, prescribed for the frame-card rail interface. The contact conductance information provided in Navy RFP N00164-90-R-0565 lists a contact resistance of 0.189°C/W for a contact area of 0.00159 m² (2.46 in.²) without specifying the associated contact temperature and pressure. The corresponding area-independent contact conductance is 3334 W/m²K. This value is used as the uncoated conductance in calculating the conductance ratios.

As listed in Table 2 and illustrated in Fig. 2, the three very soft coatings (indium, tin, and lead) provide the greatest estimated increases in thermal contact conductance. However, according to Table 1 of MIL-STD-889B (1976), lead is susceptible to galvanic corrosion in a marine environment, when in contact with the nickel plating of the C11000 copper frames. Thus, lead is excluded from consideration. Aluminum, magnesium, zinc, and cadmium coatings should improve the contact conductance. But, as indicated in MIL-STD-889B, these metals are also incompatible with the nickel plating. Bismuth is not listed in the galvanic series included in Table 2 of MIL-STD-889B, but, judging from its position to the right of lead (i.e., generally more active due to a sometimes higher valence number than lead), it is probably also incompatible.

Silver, gold, copper, palladium, platinum, rhodium, chromium, cobalt, tantalum, and, of course, nickel are all compatible with the nickel plating of the C11000 copper card rails. Although not listed in MIL-STD-889B, vanadium and niobium are both probably compatible with the nickel plating because they are almost completely surrounded in the periodic chart by metals

.that are compatible with nickel (i.e., chromium, molybdenum, tungsten, tantalum, and titanium). These harder metals (e.g., silver, gold, etc.) do not afford such large estimated improvements in contact conductance as do indium and tin.

MIL-STD-889B does not provide information on the comparability of metals in contact with anodized aluminum surfaces, such as those of the 6101-T6 aluminum frames. It is likely that dissimilarities in electric potential of the proposed coatings with the anodized 6101-T6 aluminum are less severe than with the nickel-coated C11000, because the low electrical conductivity of the anodized coating should greatly impede galvanic corrosion of the card rail coating. Nevertheless, in order to be conservative in evaluating the proposed coatings, the observations made for contacts involving the nickel-coated C11000 copper are assumed to hold for contacts involving the anodized 6101-T6 aluminum.

6.0 CONCLUSIONS

Although estimates indicate that indium is expected to provide the greatest enhancement of thermal contact conductance, its poor shear strength makes it susceptible to being worn from the A356-T61 rail surfaces with repeated removal and insertion of the SEM frames. Tin is expected to be second in terms of increasing contact conductance. However, tin platings, when mechanically or thermally stressed, have been found to form "whiskers" in electronic components. Also, at temperatures below -18°C (0°F) tin platings deteriorate into a powder.

Of the remaining metals that are compatible with the nickel plated copper frame, silver, gold, and copper are expected to provide far greater increases in contact conductance than the rest. Since copper forms a light oxide and its thermal conductance is calculated to be slightly less than that of gold or silver, copper would likely be supplanted by one of the other two. Silver also tarnishes slightly but its cost is a small fraction of that of gold. Both silver and gold are readily plated or deposited onto surfaces, and they are excellent choices for the rail coating.

REFERENCES

Ai-Astrabadi, F. R., O'Callaghan, P. W., and Probert, S. D., 1980, "Thermal Resistance of Contacts: Influence of Oxide Films," AIAA Paper no. 80-1467, presented at the AIAA 15th Thermophysics Conference, Snowmass, Colorado, July 14-16.

Antonetti, V. W., and Yovanovich, M. M., 1985, "Enhancement of Thermal Contact Conductance by Metallic Coatings: Theory and Experiment," ASME Journal of Heat Transfer, Vol. 107, August, pp. 513-519.

Antonetti, V. W. and Yovanovoch, M. M., 1988, "Using Metallic Coatings to Enhance Thermal Contact Conductance of Electronic Packages," *Heat Transfer Engineering*, Vol. 9, No. 3, pp. 85-92.

Brick, R.M., Pense, A.W., and Gordon, R.B., 1977, Structure and Properties of Engineering Materials, Fourth Edition, McGraw-Hill, New York, New York.

Cecco, V.S. and Yovanovich, M.M., 1972, "Electrical Measurements of Joint Resistance at Perfect Contact Interfaces: Application to Joint Conductance," AIAA Paper No. 72-19, AIAA 10th Aerospace Sciences Meeting, San Diego, California, January.

Chung, K. C., Sheffield, J. W., and Sauer, H. J. Jr., 1990, "Effects of Metallic Coated Surfaces on Thermal Contact Conductance: An Experimental Study," 6th Miami International Symposium on Heat and Mass Transfer, Miami Beach, Florida, December 10-12.

Chung, K. C., Sheffield, J. W., Sauer, H. J. Jr., and O'Keefe, T. J., 1991, "The Effects of Transitional Buffering Interface Coatings on Thermal Contact Conductance," AIAA Paper No. 91-0490, presented at the AIAA 26th Thermophysics Conference, Honolulu, Hawaii, June 24-26.

Fletcher, L. S., 1990, "A Review of Thermal Enhancement Techniques for Electronic Systems," IEEE Transactions on Components, Hybrids, and Manufacturing Technology, Vol. 13, No. 4, December, pp. 1012-1021.

Flinn, R.A. and Trojan, P.K., 1981, Engineering Materials and Their Applications, Second Edition, Houghton Miflin Co., Boston, Massachusetts.

Fried, E., 1965, "Study of Interface Thermal Contact Conductance," Summary Rep., G. E. Document No. 65504395, G. E. Valley Forge Space Technology Center, Philadelphia, Pennsylvania.

Fried, E., and Kelly, M. J., 1965, "Thermal Conductance of Metallic Contacts in a Vacuum," AIAA Paper No. 65-661, in *Proc. AIAA Thermophysics Specialist Conference*, Monterey, California, September 13-15.

Herb, J. A., Dailey, C., and Ravi, K. V., 1989, "The Impact of Deposition Parameters on the Thermal Conductivity of CVD Thin Diamond Films," Proceedings of the First International Symposium on Diamond and Diamond-Like Films, Vol. 89-12, Dielectrics and Insulation, Electronics, and High Temperature Materials Division, Ed. by J. P. Dismukes et al., The Electrochemical Society, Inc., Pennington, New Jersey, pp. 366-379.

Ho, C.Y., Powell, R.W., and Liley, P.E., 1974, "Thermal Conductivity of the Elements: A Comprehensive Review," Journal of Physical Chemistry Reference Data, 3, Supplement 1.

Hultgren, R., Desai, P.D., Hawkins, D.T., Gleiser, M., Kelley, K.K., and Wagman, D.D., 1973, Selected Values of the Thermophysical Properties of the Elements, American Society for Metals, Metals Park, Ohio.

Kang, T. K., Peterson, G. P., and Fletcher, L. S., 1989, "Enhancing the Thermal Contact Conductance Through the Use of Thin Metallic Coatings," *ASME Journal of Heat Transfer*, paper 89-HT-23.

Mal'kov, V. A., and Dobashin, 1969, "The Effect of Soft-Metal Coatings and Linings on Contact Thermal Resistance," Inzhenerno-Fizicheshii Zhurnal, Vol. 17, No. 5, pp. 871-879, November.

Metals Handbook, 1990, Vol. 1, "Properties and Selection: Nonferrous Alloys and Special-Purpose Materials," 10th Edition, American Society for Metals (ASM), Metals Park, Ohio.

Mian, M. N., Al-Astrabadi, F. R., O'Callaghan, P. W., and Probert, S. D., 1979, "Thermal Resistance of Pressed Contacts Between Steel Surfaces: Influence of Oxide Films," *Journal of Mechanical Engineering Science*, Vol. 21, No. 3, pp. 159-166.

MIL-A-8625E, Military Specification, 1988, "Anodic Coatings, Aluminum and Aluminum Alloys," Department of Defense, Washington, D.C., April 25.

MIL-C-26074E, Military Specification, 1990, "Coatings, Electroless Nickel, Requirements For," Department of Defense, Washington, D.C., October 30.

MIL-STD-889B, Military Standard, 1976, "Dissimilar Metals," Department of Defense, Washington, D.C., July 7.

Mikic, B. B., and Carnasciali, G., 1969, "The Effect of Thermal Conductivity of Plating Material on Thermal Contact Resistance," *ASME Transactions, Journal of Heat Transfer*, ASME Paper No. 69-WA/HT-9, presented at the ASME Winter Annual Meeting, Los Angeles, California, November 16-20.

O'Callaghan, P. W., Snaith, B., Probert, S. D., and Al-Astrabadi, F. R., 1981, "Prediction of Optimal Interfacial Filler Thickness for Minimum Thermal Contact Resistance," AIAA Paper No. 81-1166, presented at the AIAA 16th Thermophysics Conference, Palo Alto, California, June 23-25.

Peterson, G. P., and Fletcher, L. S., 1990, "Measurement of the Thermal Contact Conductance and Thermal Conductivity of Anodized Aluminum Coatings," ASME Transactions, Journal of Heat Transfer, Vol. 112, No. 3, August, pp. 579-585. Richman, M.H., 1967, An Introduction to the Science of Metals, Blaisdell Publishing Co., Waltham, Massachusetts.

Smith, W. F., 1981, Structure and Properties of Engineering Alloys, McGraw-Hill, New York.

Snaith, B., O'Callaghan, P. W., and Probert, S. D., 1982, "Minimizing the Thermal Resistance of a Pressed Contact," *Journal of Mechanical Engineering Science*, Vol. 24, No. 4, pp. 183-189.

Tabor, D., 1951, The Hardness of Metals, Oxford University Press, Amen House, London.

Touloukian, Y.S. and Ho, C.Y., Eds., 1972, Thermophysical Properties of Matter: Thermal Conductivity of Metallic Solids, Vol. 1, Plenium Press, New York, New York.

Touloukian, Y.S. and Ho, C.Y., Eds., 1976, Thermophysical Properties of Selected Aerospace Materials, Part II: Thermophysical Properties of Seven Materials, Thermophysical and Electronic Properties Information Analysis Center, CINDAS, Purdue University, West Lafayette, Indiana.

Weast, R.C., Ed., 1974, CRC Handbook of Chemistry and Physics, 55th edition, Chemical Rubber Co.

Westbrook, J. H., and Conrad, Hj., Eds., 1973, The Science of Hardness Testing and its Research Applications, American Society for Metals, Metals Park, Ohio.

Yip, F. C., 1974, "Effect of Oxide Films on Thermal Contact Resistance," AIAA Paper No. 74-693, presented at the AIAA/ASME 1974 Thermophysics and Heat Transfer Conference, Boston, Massachusetts, July 15-17.

Yovanovich, M. M., 1982, "Thermal Contact Correlations," in: AIAA Progress in Astronautics and Aeronautics: Spacecraft Radiative Transfer and Temperature Control, ed. T. E. Horton, New York.

TABLE 1: Thermophysical Properties of Candidate Coating Materials

• •

Material	Atomic Symbol	Brinnel Hardness (RHN)	Thermal Conductivity (W/mK)	Thermal Expansion Coefficient	Melting Point	Mol. Weight	Deneity	Comments'
		(kg/mm [*])		(Jum/mK)	(C)		(g/cm²)	
locium.	<u>-</u>	-	23.0	32.1	156.6	114.8	7.3	Inert, low toxicity
	đ	4	35.3	8	327.5	207.2	11.34	Inert, cumul. toxin
	Ś	ŝ	66.6	Ŕ	232	118.7	7.31	Inert
Altiminum	2	8	237.	ĸ	660.4	27.0	2.71	Oxidizes
Silvar	Aa	8	428.	10.	961.9	107.9	10.5	Oxidizes slightly
Gold	¥n	8	317.	14.2	1064.4	197.0	19.3	Inert
Conner	ō	8	401.	16.6	1083.4	63.5	8.9	Oxidizes slightly
Cadmium	3	ន	8.9 0	%	320.9	112.4	8.6	Oxidizes, toxic
Zinc	۶ ۲	8	116.	Зб.	419.5	65.4	7.14	Oxidizes
Macrosium	ž	8	166 .	×.	648.8	24.3	1.74	Oxidizes
Palladium	B	\$	71.8	11.8	1552	108.4	12.0	Inert
Platinum	٤	\$	71.6	Ö	1772	195.1	21.45	Inert
Cobait	8	\$	80.2	13.8	1490	58.9	8.9	inert
Bismuth	æ	=	7.86	13.	271.3	209.0	0.80	Oxidizes
Rhodium	æ	135	150.	60	1966	102.9	12.5	Inert
Chromium	ა	<u>8</u>	63.7	6.	1903	52.0	7.1	Inert
Nickel	Z	26	80.7	13.	1453	58.7	8.0	Inert
Nobium	£	8	63.7	80.4	1960	92.9	8.4	Inert
Tantalum	۳ ۲	8	67.5	6.5	2077	181.0	16.6	lnert
Vanadium	>	2	30.7	8.3	1730	60.9	5.96	Inert

' Reactivity in air, level of toxicity.

TABLE 2: Estimated Thermal Contact Conductance of Candidate Coatings

Coating	Atomic	Rank	Contact Pressure'	Estimated Thermal Contact	Coated/ Uncoated	Coating Thickness	Comments ⁴
Material	bounde		(pei)	Conductance ² (W/m ² -K)	Conductance Ratio*	(um)	
			25/125	163.000/756.000	48.9 /227	2.5	Comp.
	∎ á		26/125	59,700/250,000	17.9 / 75.0	2.0	lno.
	2 5		25/125	54,600/232,000	16.4 / 69.6	2.0	Comp.
At minim		4	25/125	31,500/146,000	9.45/ 43.8	3.0	lnc.
Ciber	2	10	26/125	23,200/107,000	6.96/ 32.1	4.0	Comp.
	2 3	9	26/125	18,600/ 85,300	5.58/ 25.6	4.0	Comp.
2000	ē	~	26/125	16,800/ 77,600	6.04/ 23.3	4.0	Comp.
Cadmium Cadmium	8	8	28/125	16,300/ 75,300	4.89/ 22.6	4.0	Inc.
7000	5	a	25/125	13,600/ 62,500	4.08/ 18.8	4.0	Inc.
Macazin	1 1	9	25/125	11,000/ 54,800	3.57/ 16.4	4.0	lnc.
	2 3	=	26/125	9.390/ 43,400	2.82/ 13.0	4.0	Comp.
	2 8	: :	26/125	9.120/42.200	2.74/ 12.7	4.0	Comp.
	2 6	: :	26/126	8.300/38.400	2.49/ 11.5	5.0	Comp.
COOMIC	3 a	2	26/125	B. 140/ 37.500	2.44/ 11.2	3.0	Probably Inc.
	5 5	: :	26/125	6.520/ 30,300	1.96/ 9.08	5 .0	Comp.
Charles		2 2	26/125	6,240/ 24,300	1.57/ 7.30	5.0	Comp.
	5 2	:	26/126	6.170/ 24.000	1.56/ 7.20	5.0	Comp.
Nichium	2 2	8	25/125	4,120/ 19,100	1.24/ 5.74	6.0	Probably Comp.
Tentahum	e F	9	26/125	3,940/ 18,200	1.18/ 5.44	6.0	Comp.
Vanardium	>	8	26/125	3,300/ 15,300	0.96/ 4.56	5.0	Probably Comp.
				11 with a final second			

¹ Minimum/maximum allowable contact pressures for SEM-guide rail interface.
² Calculated using theoretical prediction of Antonetit and Yovanovich (1985) for nominally flat surfaces.
³ Calculated using theoretical prediction of Antonetit and Yovanovich (1985) for nominally flat surfaces.
⁴ Calculated using theoretical prediction of Antonetit and Yovanovich (1985) for nominally flat surfaces.
⁶ Calculated using theoretical prediction of Antonetit and Yovanovich (1985) for nominally flat surfaces.
⁶ Calculated using theoretical prediction of Antonetit and Yovanovich (1985) for nominally flat surfaces.
⁶ Calculated using theoretical prediction of Antonetit and Yovanovich (1985) for nominally flat surfaces.
⁶ Calculated using theoretical prediction of Antonetit and Yovanovich (1985) for nominally flat surfaces.
⁶ Comp./inc. denotes conductance of uncoated contact is 3334 W/m²-K.
⁶ Comp./inc. denotes compatability or incompatability with Ni plating on C11000 card rail as per MIL-STD-890B (1976).

Relative Dimensionless Contact Conductance vs. Figure 1A.





Dimensionless Contact Conductance vs. Relative Figure 1B.

Pressure for Metals with Oxide and Anodic Coatings



Coated/Uncoated Contact. Conductance Ratios Figure 2:

for Candidate Coating Metals

	and the second sec					>
	ŧ					Τa
	ioir	es p	psi			qN
	ated	ductance: uncoated ce.	25 p			ïż
	ncod	unc ce.	of			Zn Mg Pd Pt Co Bi Rh Cr Ni Nb Ta
	⊐ 0	cor eas urfa	er -			Rh
	act t	uted vher v su	essi			ä
	espe K	coc s, v wdv	ā ti			C C
	+ -2-	iuse face om	ntac			Ę
	v _ wi	becc sur d fr	00 .			РЧ
	utec 34 V	ed flat aine	fo			β
	omp 33.	ou for obt	utec			Zn
	e c of c	ted is	dmo			
	tes: Ratios are computed with respect to uncoated joint	Ratios are inflated because coated conductances s calculated for flat surfaces, whereas uncoated nductance is obtained from wavy surface.	Ratios computed for contact pressure of 25 3 kPa)			cu cd
	tes: Ratio	auci Ratic cali duct	Ratios 73 kPa)			Αu
	Note 1. F		3. (17			Ag
						A
						Sn
						P P P
						<u>_</u>
1 0 2 0		2	102	20 -	- (- ($\mathbf{\dot{>}}$
		ptoubno			oated/Uno	

APPENDICES

Appendix A

Antonetti and Yovanovich (1985)

$$\frac{h_j'\sigma}{mk'} = 1.25 \left(\frac{P}{H'}\right)^{0.95}$$

O'Callaghan et al. (1981)

$$\frac{1}{R'_{t<\sigma}} = \frac{1}{R'_{sn}} + \frac{1}{R_{Mf}}$$
$$= 2\overline{a}_{sn} N_{MM} k_{sr} + 2\overline{a}_{Mf} N_{Mf} k_{Mf}$$

Peterson and Fletcher (1990)

$$\left(\frac{h_c t}{k_s}\right) \left(\frac{t}{\sigma}\right)^{0.25} = 0.83 \times 10^{-2} \left(\frac{P}{H_s}\right) + 0.11 \times 10^{-4}$$

Al-Astrabadi et al. (1980)

$$\frac{1}{R_{\text{nor}}} = \frac{1}{R_{00}} + \frac{1}{R_{\text{on}}}$$

$$= 2\bar{a}_{00} N_{A00} k_{00} + 2\bar{a}_{an} N_{AM} k_{an}$$

$$1/R_{mol} = \frac{\pi}{4\phi_1} (k_{ml} a_{ml} N_{ml} + k_{ml} a_{m2} N_{m2} + k_{ol} a_{ol} N_{ol} + k_{ol} a_{o2} N_{o2}) + \frac{\pi}{4\phi_2} (k_{ol} a_{ol} N_{ml} + k_{ol} a_{o2} N_{m2})$$

$$1/R_{mo2} = \frac{\pi}{4\phi_1} (k_{m2} a_{ml} N_{ml} + k_{m2} a_{m2} N_{m2} + k_{o2} a_{ol} N_{o1} + k_{o2} a_{o2} N_{o2}) + \frac{\pi}{4\phi_2} (k_{o2} a_{ol} N_{ml} + k_{o2} a_{o2} N_{m2})$$

 $R_{mot} = R_{mo1} + R_{mo2}$

Yip (1974)

, Chemical Rubber Company.
55th Edition
and Physics,
Chemistry o
Handbook of
NUTCE: Weals, R.C., Ed., 1974, CRC Handbook
R.C., Ed.,
:: Weals,
Source

-12-4	
231 (1)59 238 0.0 231 0.0 231 - 21-0	
(25h) -) -8-2	
(257) -30-4-2	and the second
-1-5-	
1251) - 24-8-2	
(247) -27-8-2	
-25-9-2	
+6 (243) -25-8-2	
12441 12441 -24-8-2	
237 0482	
2)8 02% 2)7 0482 (244) (243) - 2]-9-2 -22-9-2 -24-8-2 -25-8-2	
231 0359	

NUIDE UT ITAL CRIMEN MOLIN INOM Numbers in parchibits, are main numbers of

. Appendix B

									1		<u> </u>	2	<u> </u>	1 – –	2
Orhit	4		ī.		K-L-M		N - M - J -	<u> </u>	0-N-N-		-0-N-		O Z		0
0	2 0 Hc 4 00260	ہ 20	20.17 . 2-8	18 o A.r	N-N-2 N+0 46	*7 •	N) 80 - 6-11-1	×د ۲	131.30	* 2 2	-)2-(1			·	
٦.			18.44140 2-7	11 12 12	35.453	Br 231	74 904 -8 -1K-7		120.9445 -11-11-7	85 A(12101 -32-1K-		_	3	1.521
2		*: •:0	15.9944 2-6	241 S 10	32.06 2-8-6	::: %	78.46 -8-18-6	52 Te	127.60 -18-18-6	Po ::	-32-18-6		71 +) Lu -)2-9-2	<u>ت ق</u>	2-4-56-
			14.0067 - 2	51 1.++1 1.++1	10.47.176 2-8-5	33 As	14 9216	Sb • - 1	-11-11-5	Bi t	200.0000 -32-18-5		. Yb, +2	20 No	-32-6-2
4			2-4	Si ti	28.06h	51 22 22	T 3.77	27 27 28	111.00 1-11-11-	52 Pb ::	-)2-18-4	٠	1 - 69 Tm 54(9 44)		-31-8-2
-		÷ ₽	10.81	51 • • • •	26.9K154 2-8-3	י פי מי	1-11-1-1 -11-1	≎ <u>⊏</u>	-114 82	11: 12: 14:	204 17		ET +1	8 <u>.</u> 8	-10-11-2
â		<u>I</u> =				Zn Zn	65.38 -8-18-2	5 5 5 5 7 5 7 5 7 5 7 7 7 7 7 7 7 7 7 7	112.40	80 +1 Hg +2	-12-18-2		67 +) HO 164 • Mu	٤ ٣	~++ +52-
4			•	Elements		177 20 20		47 Ag	107.848 -18-18-1	1: 02 Au :!	196.9665 -32-18-1		10 10 10 10 10 10 10 10 10 10 10 10 10 1		1251) - 28-8-2
F					{	?; 87.Z	58.71 -1-10-2	46 ÷2 Pd ÷3	10-1-11-0	14 1d	2-41-21- 00 501	•	1 + 29 1 Th 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	84 :: Bk	(247) -27-8-2
-		uration			Group K	Co ∷	-11-1-	45 • J Rh	102.9055 -18-16-1	77 :: r	-12-15-2		1. Da		1247) -25-4-2
				ł		26 Fe ::	55.847	4 Ru	101.07	% % 0	190.2 -32-14-2			95 Am	1243) 1243) -25-8-2
R	CHART			a Elements		25 . 2 Mn: 1	2-(1-1- 2-(1-1-	43 :: Tc ::	94.90%2 -18-13-2	75 Pe ::	-32-13-2		59 S3 19		12441 12441 -24-K-2
48	KEY TO CI			Transition		::: تي ت	31 996 -11-11-1		95.94 -1K-1 1-1	•• <u>*</u> 2	18.1.85 -32-12-2		Part 19		237 0402
ş		Alonic Number Symbil Alomic Weight				***	50.441s		42.4064 -18-12-1	5°.		ह ।	1 P 8 Z 8 Z		20 MC2
		Alonik Alomk			N	in the second se			91 22 		-12-10-2	101	59 +3 Pr 140.407		4-2
4			•			22 T	4556 T		NN 4054	1 15	134.4055	89			232 0381
	:	₽ 8 8	9.01218	ž ž Š	50(12	~	- 3	-	17 62 1		137 M	88 +2 Ra 21 - 1024			ç
				1.	1077		5	-	NS 467.	1	1-1-1-1	87 +1 Fr	•t anthanules		******
L	1	- 1. 1.													

PERIODIC TABLE OF THE ELEMENTS

:

Appendix C

Published Experimental Data on Coated Contacts

Key to tabular quantities:

Bc	Linear thermal expansion coefficient of coating, µm/mK
Del-1,2	Roughness of surfaces 1 and 2 (RMS/Avg.), μm
Ec	Elastic (Young's) modulus of coating, GPa
Es	Elastic (Young's) modulus of substrate, GPa
h	Thermal contact conductance, W/m ² K
Hc	Hardness of coating, MPa
Hs	Hardness of substrate, MPa
Hc, BHN	Brinell Hardness of coating, kg/mm ²
Hs, BHN	Brinell Hardness of substrate, kg/mm ²
kc	Thermal conductivity of coating, W/mK
ks	Thermal conductivity of substrate, W/mK
Р	Apparent contact pressure, kPa
Slope-1,2	Asperity slope of surfaces 1 an 2 (Absolute/Radians)
Tm	Mean interface temperature, C
t1,2	Coating thickness on surfaces 1 and 2, μm
wave-1,2	Waviness (flatness deviation) of surfaces 1 and 2 (Avg./Max.), µm

							_		_																	•								-						_						
Slope-Z																												_													-			<u>.</u>		
Slope-1																																														
Wave-1 Wave-2 Slope-1 Slope-2	Ę	3	23	22	22	22	ว	25		33	3	23	51	51	1] [<u>.</u>	<u>.</u>	<u>.</u>	E.I	1.3	CI	13	1.3	1.3		1 5	1:	71	12	12	\$	\$	\$		\$	Ξ	11	11	11	=	12	: :	12	: :	12
Vave-1		2	1.3	13	1.3	1.3	13		3 5	<u>,</u>		1.3	•	0	C	•			•	0	0	0	•	•	0	ľ	1 ;	2 ;	21	2	12	\$	\$	\$	\$	\$	11	11	11	II	: =	12	1:	12	15	:2
Del-2	E B				-	1	-		4 ,		-		0.3	0.3			5	5.0		6.9	0.3	0.3	0.3	03	10				1.7	1.7	1.7	1.85	1.85	1.85	1.85	1.85	1.075	1.075	1.075	1.075	1 005	0.025				0.925
Del-1	-	0.6	0.6	0.6	0.6	0.6	9.0			0.0	9.0	0.6	0.6	0.6			0.0	0.0	9.0	9 .0	0.6	9.0	9.0	0.6	90			1.7	1.7	1.7	1.7	1.85	1.85	1.85	1.85	1.85	1.075	1.075	1.075	1.075	2 M I	200				0.925
3	_	899	8	z	38	3	3 3	3 8	8 (8	3	38	4	9	: 5	2 :	? :	?	\$	\$	ŧ	\$	\$	\$: 5		ì			à	à	7	11	7	1 L	1	11	11	1	7	; 5	125		i i	<u>i</u>	3 2
	OPa 0	102	50	Ā	50		į	ił	R	5	à	507	Sec.	Sec.	1	R		R	Ā	à	Ā	5	202		Ę		Ì		Ā	Ā	Ā	En la	à	Fa .	50	Se .	5	Lat			Į	Į	1	i i	į	i A
Be I		127	ห	2	X	X	<u> </u>	3 2	9	ม	ม	X	ž	۱×	3 2	9	ล	ห	ห	8	ห	ห	22	X	1 %		3	13	13	5	13	19	19	19	19	19	19	6	2	2	2 2	144			3	166
T	ЪХ	167	23	122	737	įĘ	à F	à	57	R	53	737	3	3		2	156	15	156	156	156	156	15	3	3 3	2	8	8	8	8	8	Ş	5	Ś	ŝ	Ś	ŝ	4	ž	Ĭ	Ì		} {	2		5 6
2	mK.	15.21	15.2	15.2	15.2			1.01	15.2	15.2	15.2	15.2	Ş			15.2	15.2	15.2	152	152	15.2	15.2	15.2	15		761	187	182	182	18.2	18.2	18.2	18.2	18.2	18.2	18.2	18.2	18.2	18.2	e e		101		201	2	23
		686.7	686.7	696.7	F 20	1.202	/ 000	Ì.	686.7	686.7	686.7	C 287	L YOY	1.002	1.000	686.7	686.7	686.7	686.7	686.7	686.7	696.7	C 282	EX3		1080	C KN	EVEN	EF62	ENSZ	ENGZ	196	5	198	196	196	198	3	5		ē ē		10/01	13/3.4		1373.4
THe		2550.6	2550.6	Y S	2450.6		0.000	0.000	2550.6	2550.6	2550.6	20220		2.00	0.000	2550.6	2550.6	2550.6	2550.6	2550.6	2550.6	25506	20220	2000		0.0002	599.03	[399.03]	500.665	50.665	500.003	500 G3	500.00	500.003	500.005	50.03	500.005	20 005					50.66	51.66	3.44	599.03
LE RHNI HA	MPa MPa	L		_	3 7 2 7			2	ม 2 2	ਸ 2 2	20		4 7 2 8	4 d 2 g	2	א פ פ	2	200		2						-	_	_	300												_ ,	_				140 I
THe RF	ke/mm2							_		_						_	_	_	_	_) e) 5	2 5	3 5	2 5	3 5	3	3	3	8
He RHNTE	ke/mm2		992						2	ž	392				S	3	ষ্ঠ	Ř	260	98	2,0	920		33		260	16	163	163	163	163	163		191	163	163	1	3 5			<u> </u>		9	2	× ;	4 4
	_	P					ę. 1	1.9	1.9	1.9	0		1.7		•	0	0	0	0	0	•	• <		•		0	0	•	0	0				-		_	• •	> <	• <	> <	• •		•	-	•	> 0
ļ		F	17	1	1:	1	15	13	1.5	1.5		1:	J (2	3	7	7	2			• •	4 6	4 (N	2	22	2	2	2	1 2	1 ×	3 ¥	1 X	2 %	3 X	3 %	3 2	3 2	3 2	93	A 1	<u>ุ</u> ล :	21	8	8 X
		Ē			Ä		313	31.5	30.5	8	i e		Ŗ	31.9	29.62	1.00	34.8	E.M.	_							_	-057	550	-															_		
	V/m2K					1636	300	6119	1471	3741	Ę		3	ER .	Ę	INT	8	3	1	222	12110				2882	12	0/JE	3770	4760	DYCS	3									10/11			1000	16670		
-			R E	R	8	2202	5816	84	2063	2018		R	5	I	100	1646	3	Ę,	1480					5	2765	648	450	1150	05.92	9	3			222					R II		9614		8	1150		5 7 7 8 7 8 8 8 8 8 8 8 8 8 8 8 8 8 8 8
ſ		T	2				lied.																				nte -		Ley																	
	Malenals		Substitute	5, 3		Vapor	Deposited	2						M													d Substrate		KAIRNOT			Z <	2										ð			
		Kelerenos	Fried and	Kelley,	8																						Ma kov and	D-bachin.																		
	0	NO. NC		2	1963																								1 2	-																
1										-		_												_	_					-																

																			_						_								_	
Slope-2		162.0	120	12.0	1570	12.0	0.231	162.0	0.233	.233	52.0	673	0.233	62.0	22.0	0.252	0.252	0.252	0.22	0.252	0.252	0.252	0.232	0.232	0.23	0.23	0.232	0.232	0.24	10.0	•27•	a.	0.24	0.224
Slope-1		0.03	0.03	0.03	0.03	0.03	0.03	0.03	0.031	0.031	0.031	0.031	0.031	0.031	0.031	0.038	0.038	0.038	0.038	0.038	0.038	0.038	0.022	0.022	0.022	0.022	0.022	0.022	0.027	0.027	0.027	0.027	0.027	0.027
Wave-Z	85	1	-	÷.		-	1	-	-	1	-	-				-	-	-	1	1	1	-	-	-	-	-	-	-	1	_	1	-		1
Wave-1 Wave-2 Stope-1 Stope-2	E S	-	1	-	-	1	1	1	1	pred	1	1	-		1	-	-	1	1	1	1	1	1	-	1		-	1	-		1	-		1
Del-2		90'1	4.06	\$	4.0	8 .	4.8	4.06	4.24	4.24	4.24	4.24	424	4.24	4.24	4.45	4.45	4.45	4.45	4.45	4.45	4.45	87. •	89 97	8	86.4	8	86. 4	4.19	4.19	4.19	4.19	4.19	4.19
Del-1	Ħ	61.0	0.19	0.19	0.19	0.19	0.19	0.19	0.2	0.2	0.2	0.2	0.2	0.2	0.2	0.27	0.27	0.27	120	0.27	12.0	0.27	0.14	0.14	0.14	0.14	0.14	0.14	0.21	0.21	0.21	0.21	0.21	0.21
	GPa	14	r	1	1	11	7	7	7	1	2	11	11	L	r	1	11	5	1	11	2	1	1	2	1	1	7	7	7	2	1	7	11	1
93		102	E.	à	R	5	à	50	5	5a	à	F	2	à	5a	5	Ā	50	à	Fa	F	52	52	A	R	F	5	F	5a	S	A	F	ā	S
	ww/wK	6 I	19	1	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19
3	W/mK	57.1	\$	2	24	2	24	24	24	24	57	2	2	5 2	2 2	2 4	23	\$2	3	425	425	23	\$	425	2	5 2	3	24	24	224	23	42	\$	\$
8	W/mK	11	7	7	7	7	7	7	F	7	H	7	7	7	7	7	7	7	7	7	7	7	7	4	7	7	7	4	4	7	7	7	7	4
Нс	MPa	¥76£	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4	392.4
Γ	W	2043	ENGZ	ENGZ	E da	EH62	2943	2943	ENG	ENGZ	2943	ENGZ	2943	ENGZ	ENG	ENG	ENGZ	EXA	ENG	ENG	EVER	2943	ENGZ	EM2	EN6Z	2943	2943	2943	ENGZ	ENGZ	2943	ENGO	EVEN	ENGZ
HA, BHN HC, BHN HG	Vana V	ŧ	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	Ŧ	\$	\$	\$	\$	\$	ŧ	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$
PHINH	2	Ļ	300	800	8	900	800	8	8	8	300	8	8	900	8	8	8	8	8	80	8	8	8	8	900	8	8	900	8	800	8	ŝ	8	8
H	ke/mm2	-	•	•	•	0	0	0	0	•	0	0	0	0	0	0	0	0	•	0	0	0	0	0	•	•	•	•	0	0	0	0	0	•
2	9	E	1.4	1.4	1.4	1.4	1.4		51	5.1	51	51	5.1	51	5.1	39.5	2.05	39.5	39.5	39.5	39.5	39.5	0.81	0.81	0.81	0.81	18.0	0.81	1.2	1.2	1.2	1.2	12	1.2
	8	t	9																					_	_									
F	W/m2K C	L	6200 206		3200	6700	0000	00522	1200	2500	000	25500	00016	8000	0008	2000	00072	35000	19000	51000	61000	00050	2350	3550	5200	802	8003	12800	3200	5700	8300	11000	13600	19500
P Cond, h		260	000	490	8	200	959	Ş	3									1500										3700		0/0	1500	2100	8	3500
I Press, P	E.		1		-										. eri																			•••
Materials		Substrate	Ni 200		Variation	demailed		•		Series A																								
E		- P				-	_	_		-		_															_							
W.	Reference	L			}	Cont																												

																	_							_	_				-	
Slope-2		20.0	6.0.0	6.00	6.00	0.03	0.079	0.079	0.00	0.079	0.020	0.079	6.03	0.079	0.070	0.078	0.03	0.078	0.078	6.63	0.078	0.078	0.078	0.078	0.078	0.078	0.038	0.078	0.078	
Wave-1 Wave-2 Slope-1 Slope-2		8	8	0.08	0.08	0.08	0.08	0.08	0.08	0.08	0.08	0.08	0.08	0.08	0.08	90.0	9 .0	0.08	0.08	0.0	0.0	90.0	0.0	90.0	.0.0	0.08	80.0	0.08	80.0	
Vave-Z	Ba	7489	2,489	2,489	2,489	2.489	2,489	2.489	2,489	2.489	2,489	2,489	2.489	2,489	2.489	2.591	2.591	2.591	2.591	2.591	2.591	2.591	2.591	2.591	1657	2.591	2.591	2.591	2.591	
Vave-1	-1	99777	2286	2,286	2.286	2,286	2.286	2,286	2.286	2.296	2.286	2.286	2.286	2.286	2,286	57	57	37	254	25	ちっ	57	22	57	254	25		_	2.54	
Del-2	-	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0 7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7747	0.7147	0.7747	0.7747	0.7747	0.7747	0.7747	0.7747	0.7747	0.7747		_		0.7747	
Der	_	0.6858	0.6858	0.6858	0.6858	0.6858	0.6858	0 6858	0.6858	0.6958	0.6858	0.6858	0.6858	0.6858	0.6858	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417	0.7417		ł
Ee		Ħ	4				1	1	53	1	1	1	1	1	1	\$	\$	4	4	1	1	4	4	4	4	1	4	. 1	4	
	-	6	3	8	9	5 9	5 9	5 9	5 9	6 9	8	8 9	9	5 9	8	3	\$	8				; \$						3 S	_	
	Хq	F	8	1 8	18	3 8	3 8	3 8	3 8	R 8	3 8	3 8	3 8	3 8	3 8	8 8		8								. 8	\$ 8	8 8		
	R X	t.	76 75			2.0	0/.00	2.0	2	6.3	22	2.3	2.3	00	2.3		2.25	21. XX	2. 37 7 2 37	2.2	2.00									
Ī	W/mK					2	5	2	2	2	2	2 8	2	2	2															
F		-		0	~	~	0	0	0	2	2	2	8	8	83	5.5	3 8	S X	20.74	53	S X	6 8	S X	3	5	53	53	53		
	. .			6.5	6.4	6.64	66		50.64	19.05	49.05	49.05	60.64	6	5.6 1	Ż	¢ q	È q		\$ \$			÷ 4		•					2.4
	e X						_		981 49.0	_	_			961 49.																A:44 194
Ī							_		_	_	_																			
Ī							2 881	2 381	5 981	5 981	5 961	5 981	286	S 961	5 381 5 1					2										
Ī					S 981	5 281	2 881		5 981	_	5 961	5 981	286		5 381 5 1					2										
Ī	HAN HA, BHN HA				S 981	5 281	2 381	2 381	5 981	5 981	5 961	5 981	286	S 961	5 381 5 1					2										
Ī	12 HA, BHN HG, BHN HS				S 981	3 0 100 5 981 4	3 0 100 5 981	1 0 100 5 981	3 0 100 5 981 ·	3 0 100 5 981	3 0 100 5 961 ·	3 0 100 5 961	100 100 5 981 v	3 0 100 5 961	5 381 5 1	0 100 5 961				0 100 2 200	0 100 5 961					0 100 5		0 100 5		1.8202 0 100 2 202
Ī	a 11 12 HA, BHN HG, BHN HS			3 0 100 5 961 v	25 1.2598 0 100 5 981	25 1,2596 0 100 5 981	25 1.2596 0 100 5 961	25 1,2596 0 100 5 981 4	25 1 2598 0 100 5 981	25 12596 0 100 5 961	25 1.2596 0 100 5 961	25 1.2598 0 100 5 981	25 1.2598 0 100 5 981 4	25 1.2598 0 100 5 961	25 1.2596 0 100 5 961	25 1.2596 0 100 5 961	25 1.8202 0 100 5 Yel		25 1.8202 0 100 100 21 25	25 1.8202 0 100 5 761	25 1.8202 0 100 5 961	25 1.8202 0 100 5 761	25 1.8202 0 100 5 701	25 1.8202 0 100 20 1.8202 1 22	25 1.8202 0 100 5 ³⁶¹	25 1.8202 0 100 5 901	25 1.8202 0 100 5 ³⁰¹	25 1.8202 0 100 5 961	25 1.8202 0 100 5 701 F	25 1.8202 0 100 21.8202
Ī	TIM 11 12 HA, BHN HG, BHN HG			0 25 12598 0 100 5 981 4	25 1.2598 0 100 5 981	25 1,2596 0 100 5 981	25 1.2596 0 100 5 961	25 1,2596 0 100 5 981 4	25 1 2598 0 100 5 981	25 12596 0 100 5 961	25 1.2596 0 100 5 961	25 1.2598 0 100 5 981	5660 25 1.2598 0 100 5 981 v	6424 25 1.2598 0 100 5 981	7158 25 1.2598 0 100 5 981	7826 25 1.2598 0 100 5 961			104 C 001 0 2021 SZ 444	S40 25 1.8202 0 100 5 961	710 25 1.8202 0 100 5 901	818 25 1.6202 0 100 5 961	928 25 1.8202 0 100 5 928	1042 25 11.8202 0 100 5 10 100 5	1133 25 1.8202 0 100 5 961	1264 25 1.8202 0 100 5 991	1467 25 1.8202 0 100 5 104 1	1669 25 1.8202 0 100 5 961		2140 25 1.8202 0 1001 2 28
Ī	a, P Cond, h Tm 11 12 HA, BHN HG, BHN HS	W/m2K C um um the kymmu Kymmu Nymuu Mi		1200 25 1.2596 0 100 5 961	1729 25 1.2598 0 100 5 981	25 1,2596 0 100 5 981	Z731 25 1.2596 0 100 5 961	3152 25 1.2598 0 100 5 981	2675 25 1.2598 0 100 5 981 c	25 12596 0 100 5 961	4400 25 1.2596 0 100 5 961	4973 25 1.2598 0 100 5 981	5660 25 1.2598 0 100 5 981 v	25 1.2598 0 100 5 961	7158 25 1.2598 0 100 5 981	7826 25 1.2598 0 100 5 961			104 C 001 0 2021 SZ 444	S40 25 1.8202 0 100 5 961	710 25 1.8202 0 100 5 901	818 25 1.6202 0 100 5 961	25 1.8202 0 100 5 701	1042 25 11.8202 0 100 5 10 100 5	1133 25 1.8202 0 100 5 961	1264 25 1.8202 0 100 5 941	1467 25 1.8202 0 100 5 104 1	1669 25 1.8202 0 100 5 961	1922 25 1.8202 0 100 5 1921	2140 25 1.8202 0 1001 2 28
Ī	a, P Cond, h Tm 11 12 HA, BHN HG, BHN HS			x 181 1200 25 1.2596 0 100 5 961	24 0 1729 25 12598 0 100 5 981	2437 2243 25 12598 0 100 5 981	Z731 25 1.2596 0 100 5 961	croso 3152 25 1.2596 0 100 5 981	xer x 25 12598 0 100 5 961	A11A 25 1.2596 0 100 5 981	4400 25 1.2596 0 100 5 961	4973 25 1.2598 0 100 5 981	5889 25 1.2598 0 100 5 981	6424 25 1.2598 0 100 5 981	7158 25 1.2598 0 100 5 981	7826 25 1.2598 0 100 5 961			104 C 001 0 2021 SZ 444	S40 25 1.8202 0 100 5 961	710 25 1.8202 0 100 5 901	818 25 1.6202 0 100 5 961	928 25 1.8202 0 100 5 928	1042 25 11.8202 0 100 5 10 100 5	1133 25 1.8202 0 100 5 961	1264 25 1.8202 0 100 5 941	1467 25 1.8202 0 100 5 104 1	1669 25 1.8202 0 100 5 961		2140 25 1,8202 0 100 5 29
Ī	Press, P Coad, h Tm 11 12 Hs, BHN He, BHN Hs	W/m2K C um um the kymmu Kymmu Nymuu Mi		x 181 1200 25 1.2596 0 100 5 961	Automit-10 25 1.2598 0 100 5 981 4	2437 2243 25 12598 0 100 5 981	446 2731 25 1.2598 0 100 5 981	croso 3152 25 1.2596 0 100 5 981	xer x 25 12598 0 100 5 961	A11A 25 1.2596 0 100 5 981	4400 25 1.2596 0 100 5 961	4973 25 1.2598 0 100 5 981	5889 25 1.2598 0 100 5 981	6424 25 1.2598 0 100 5 981	7158 25 1.2598 0 100 5 981	7826 25 1.2598 0 100 5 961			104 C 001 0 2021 SZ 444	S40 25 1.8202 0 100 5 961	710 25 1.8202 0 100 5 901	818 25 1.6202 0 100 5 961	928 25 1.8202 0 100 5 928	1042 25 11.8202 0 100 5 10 100 5	1133 25 1.8202 0 100 5 961	1264 25 1.8202 0 100 5 941	1467 25 1.8202 0 100 5 104 1	1669 25 1.8202 0 100 5 961		2140 25 1.8202 0 1001 2 28

	_																												コ	
Slope-4		0.085	0.085	0.085	0.085	0.085	0.085	0.085	0.085	0.085	0.065	0.083	0.085	0.085	0.065	0.081	0.081	0.001	0.081	0.081	0.081	0.08		0.081	0.08	0.08	0.0	8.0	0.08	
lope-1		0.083	0.083	0.063	0.083	0.083	0.083	0.083	0.043	0.083	0.083	0.083	0.063	0.063	0.083	0.084	0.084	0.084	0.084	0.084	0.084	0.084	0.084	0.084	0.084	0.084	0.084	0.064	9.064	
ave-2 S	-	155.2	2.337.	2.337	2.337	2.337	2.337	2337	2.337	2.337	2337	2.337	2.337	2.337	2.337	2.235	2.235	2.235	2235	2235	2235	2235	2.235	2.235	2.235	2.235	2.235	2.235	2235	
Wave-I Wave-2 Slope-1 Slope-4	B	5777	2235	235	2235	235	2235	235	1235	2235	2235	2235	2235	2.235	2235	2,286	2.286	2.286	2.286	2.286	2,296	2,286	2.286	2.286	2.286	2.286	2,286	2286	2.286	
		L								0.6858		0.6858			0.6858		1710.0	<u> </u>	_	_	_	_	0.6477	0.6477	0.6477	0.6477	0.6477	0.6477	1742.0	
Z-IPCI	83	E					_						_				_	_						0.6965 0.					0.6985 0	
Del-1	an	-	-	_				_	_			_		-		74 0.6985			_			-	-	_			_			
ŝ	e de	-														1274										80		_		
ş	12		3		59		38	3 9			\$: S	8		3 8	. 8	. 8													
3	i s i		1	i i	35		12	1	3 5	i i		12	12	i 5	15	18	i ē	1 i		i 5			8		3			8	8	
Ì		-		88	8 5	8 8	8 8		89.57	2 2 2	20.04		200					3 8		2 2 2	3 8	382	22.88	200				21.88	23.68	
I	2	_	2		2		2		21	2												2	2	2				<u></u>	621	
Ë			18.4	19.6	18.6	19.6	1876	19.6	18.9	18.9	1976	10%	10.4	10%	19.4	10.2	10.4	10.4	19.4	1976	10%	10%	10.7		10%	19.4	10.4	10.7	18.6	
		Ň	5	198	3 87	100	198		81	196	5	19	R		196			10	ER 3	1		R 8		R 2	Ŕ					
	£	MPa	86	×.	8	x	.	ж 	.	.	<u> </u>																			
	C, BHN Ha	ymm2	1	-	1	-	-	-	-	-	-				****	-							- •							
	Ha, BHIN HG	um2 kg/	001	8	10	<u>1</u> 8	8	8	<u>10</u>	8	8	8	8	8	8	8	8	8	8	8	8	8	8	3	8	8	8	8	8	
	Ha	kg/mm2	10	•	•	•	•	0	•	•	•	•	•	•	•	•	•	•	•	•	•	•	0	0	•	•	•	0	-	
	71	g			_	-			-	3	5	6	0	0	0	0	2	3	2	3	3	23	2	23	3	3	62	3	3 5	84
	11		0057	2.5003	2.500	2,500	2,500	2.500	2,500	2500	2500	2500	20057	2500	2500	25003	5 0.2762	_	5 0.2762	_	5 0.2762	5 0.2762	20 27	5 0.2762	5 0.2762	5 0.2762	25 0.2762	-		70/7·N C
	8	U	+-	22	2	2	2	2	8	2	2 2	22	2 2	57 0	17 17	ਸ 	8	0 22	ਲ 2	22	8	8 8	27 28	2 2	2	3				
	Cond. h	W/m2K	ARIS	9636	1162	1458	1648	1822	1960	2118	202	220	2612	2810	30962	1995	191	รัส	31	1834	ş	8458	288 2883 2883	11396	10021	14134	16381			21611
	Press P		T M	122	282	346.8	116	0.025	5003	710.9	794.8	887.5	1055.3	1236.4	1413	1580.8	106	176.6	264.9	353.2	450.4	534.3	613.8	2 2 2 2	806.1	905.2	1059.7	1231.9	1421.8	1589.6
	Г		T	. 2																										-
	Versent				n 1-1000 TV	Viene		ucpumu. In	9																					
	F		t		<u>*</u>				•																					
				Vang. 1707	ç																									
		2	ź	2																										

0.068 0.068 0.068 0.068 0.068 0.068 0.068 0.068 0.085 0.085 0.085 0.085 0.065 0.068 0.088 0.068 0.068 0.068 888 0.085 0.085 0.085 0.085 0.085 0.065 Slope-2 0.083 0.062 0.082 0.062 0.062 0.062 0.082 0.062 0.062 0.082 0.082 0.082 0.064 0.084 0.084 0.064 Wave-IJ Wave-2 Slope-I 190.0 0.084 0.084 0.084 0.084 0.084 0.084 2337 **** 333 25 2.54 2 3 22 g 2.032 2.032 2.032 2.032 2.032 2.032 2.032 2.032 2.489 2.032 2,489 2,489 2.032 2.489 2,489 2.489 2.489 2,489 2.489 2,489 2.489 2,489 2.032 0.7112 0.7112 0.7112 0.7112 0.7112 0.7112 0.7112 0.7112 0.7112 0.7112 0.7112 0.7747 0.7747 0.7747 0.7747 0.7747 0.7147 0.7747 0.7747 0.7747 0.7147 0.7147 UE 114 Del-7 0.6965 0.6553 0.6985 0.6985 0.6985 0.6985 0.6965 0.6553 0.6985 0.6985 um 0.6553 0.6553 0.65533 0.6985 0.6985 0.6983 0.6983 0.6983 0.6553 0.6553 0.6553 0.6553 0.6553 0.6553 0.6553 0.6553 0.6985 Del-I 12.74 1274 12.74 12.74 12.74 12.74 1274 1274 12.74 1/21 12.74 2.7 12.74 274 27 22 2.7 2.2 12.74 12.74 12.74 GP. Bc Ba um/mK GPa ដ្ដដ្ដ 22 22222 32.1 ä ä ğ 122122122122 员 ង្គ 2 ਕ Ы 23.88 23.88 lic W/mK 8 2 8888 8 8 8 £ 2 8 ks W/mK 22 EEEEEEEE 8 ы Мр **8 8 8 8 8** 19 55 5 8 **8**888 Ha, BHN | Hc, BHN | Hs kg/mm2 | kg/mm2 | MPa 0 þ 🛿 1417 1.4417 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 3.7053 1.4417 111 1417 1.417 114. 2023 1117 1417 417 1417 114. 111 EC07.E 늘 별 <u>ุ มุมมุม มุมมุม</u> どどど 2 2 2 8 C 111181 13266 14993 16399 18502 19822 21589 24151 26853 26853 26853 26853 730A 8198 12439 13591 3430 53356 57793 57793 57793 57793 E.S 2006 S ž Ë 517 Cond, h W/m2K 702.1 803.6 878.7 878.7 878.7 1068.6 1231.9 1231.9 1204.2 1589.6 534.3 264.9 353.2 441.6 441.6 534.3 613.8 613.8 770.9 874.3 874.3 874.3 11059.7 1231.9 75.1 203.1 260.5 353.2 411.6 1585.2 Press, P kPa Ľ. Substrate Al 6061-76 Vapor deposited In Materials Kang, 1989 Reference Sont. No. 6

0.063 0.083 0.082 0.082 0.003 80.0 80.0 80.0 8.0 8 8. Slope-Z 8.0 8 8 80.0 0.078 0.078 0.078 0.078 0.078 0.078 0.078 0.078 0.078 0.078 0.061 0.081 0.081 Slope-1 0.078 0.081 0.081 0.081 0.081 0.061 **190**.0 0.081 0.081 0.081 0.081 8/010 2.667 2.667 2.667 2.667 2667 2413 2413 2.667 2.667 2.667 2413 2413 2413 2413 2.413 2413 2413 Wave-I Wave-Z EE ş 5555555 2413 2413 2413 2413 2413 2413 2.413 2413 1337 1331 557 2.413 2.413 2.413 2413 ES 1 Ę 2331 ELVZ 0.7874 0.7874 0.7874 0.7874 0.7874 0.7874 0.7874 0.7874 0.6782 0.6782 0.6782 0.6782 0.6782 0.7874 0.7874 0.7874 0.7874 0.7874 0.7874 um 0.6782 0.6782 0.6782 0.6782 0.6782 0.6782 0.6782 0.6782 Del-2 0.6782 0.6782 0.6782 0.6782 0.6782 0.7112 0.7112 0.7112 0.7112 0.6782 0.6782 0.6782 0.6782 0.6782 0.6782 0.6782 0.6782 0.7112 0.7112 0.7112 0.7112 0.6782 2117.0 0.7112 0.7112 0.7112 0.7112 Del-1 B 0 0 2 <u>•</u> <u>م</u> • 0 9 000 <u>•</u> 2 <u>o</u> • <u>•</u> 2 Ð 0.0 • 9 ٥. 2 2 0 • a Ba \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ \$ 3 3 \$ \$ \$ \$ \$ 3 2 22 \$\$ 222 a o <u>.</u> Bc um/mK kc W/mK RRR REFER R 2 E 6 ka W/mK r F R ***** 39.24 33.24 YZ:66 He MP 55 55 555 5 8 둜 Ha, BHN He, BHN Ha kg/mm2 | kg/mm2 | MPa • . 0 0 • 0 0 0 0 -0 0 0 0 0 5 3 11 400 0.2518 0.251 T and **** 8 υ 20134 20134 21258 21258 10328 11922 12611 12611 13536 15020 10469 111061 111964 12199 5559 3005 4053 5983 6730 6730 8299 8955 30 88 25 200 66 W/m2K Cond. h 883.1 1064.2 1289.3 1413 1585.2 543.1 622.6 796.5 799.2 181 278.2 278.2 538.7 538.7 538.7 710.9 7710 176.6 273.8 357.7 41.6 8 Ê Press, KPa Substrate Al 6061-T6 Vapor deposited Pb Materials Reference Kang, 1989 ы С Ś 5

																															_	
Slope-Z		0.081	0.081	0.081	190.0	0.081	0.081	0.081	0.081	0.081	19970	0.001	0.081	0.0	0.081	0.065	0.095			0.00	0.083	0.085	0.065	0.085	0.065	2000			200	0.005	0.085	
Wave-I Wave-Z Slope-I Slope-Z		8/0'0	0.078	0.078	0.078	0.078	0.078	0.078	0.078	0.078	0.078	0.078	0.078	0.078	0.078	0.065	200			0.065	0.083	0.085	0.085	0.065	0 ORS			0.063	0.083	0.085	0.085	•
Wave-2	E S	155.7	2337	2.337	2331	2307	2337	2.307	2337	2.337	2337	2337	2337	2.337	2.337	2.235	2225		(77	223	2235	2235	2235	2235	2266		57	2235	223	2235	2235	
Wave-I	B	12	254	254	25	52	254	2.54	2.54	3	ちれ	24	2.54	2.54	2.54	and C	3	22	37	2301	2337	1927	2337	2337	122.6	3	1927	2331	23	2337	2337	
Del-2	B	0.7163	0.7163	0.7163	0.7163	0.7163	0.7163	0.7163	0 7163	0.7163	0.7163	0.7163	0 7163	0 7163	0 7163	0.6085		0.0900	0.6983	0.6985	0.6985	0.6985	0.6985	0.6085	2007 0		0.6983	0.6985	0.6985	0.6985	0.6985	
Dell		22	0.9052	0.8052	0.8052	0.9052	0.8052	0 9052		10000	0.8052	0.8052	0.9052	CYUE -	0.005			0.6909	0.6909	0.6909	0.6909	0.000	0.6400			567	0.6909	0.6909	0.6909	_	_	4
F	GPa	Þ	2	61	01	2	2	2	1 9	1 2	12	2	2		1		2	19	19	10	61					-	61	61	61			
F		F		\$					-	6 9			8			6 \$	_	8											_	_	\$ \$	
1	M K		1 8	3 8	1 8	38	4 8	3 8	4 8	38	8 8	4 8	38	98	4 8	4	2	8	2	8	1 8	3 8	98	4 8	4	8	8	8	2	3 8	8	
ļ	X		5.5					5.5	1.15		5.5		5.1		10.15	10.15	3.12	3.6	37.04	2			5			3.5	31.6					
Ī						21	2		6	<u>e</u> [<u>E</u> [2	2	E	E	Ē	<u>F</u>	5	Ē	-			2	51	61	2	2					
	o E	Mrs	17.65	17.66	5.6	20.24	17.6E	17.65	39.24	39.24	39.54	77.66	¥7.6£	39.24	39.24	39.24	39.24	39.24	10.74		5.6	5.6	17.66	17.66	39.24	39.24	30.24	2 C Q2				57.CC
Ī			196		Ŕ	5		196	196	196	196	8	i k	198	198	196	196	196	8		R		196	8	198	198	3		Ŕ	Ŕ		I
		/mm2 MFa	+	4	•	4	*	4	4	*	*	4	4	+	4	*	4	-		•	•	4	4	•	+	4	• •	•	•	•	• •	╡
	N HC, E	2		-	_	_	8	~	0	8	2	8	2	8	8	8	8		2 2	3	8	8	8	8	8	a la	2	3 8	B	8	8	8
	Ha, aH	ke/mm2		8	8	8	2	2	8	10	2	2	×	¥	7	7			-	-	-	-	-	-	-	-						
	77	an Mu	P	•	•	•	•	•	•	•	•	•	•	• 	• 			• •			<u> </u>	-										
	1	83	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	4.0052	~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~~		2.0.6			5.022	5.0222			_		_				5.022
		υ	2	ม	2	ห	ห	ห	ž	ิ X				2	25	12					<u>ร</u>	2	22	ุร 1				2				22
	Cond, h	W/m2K	3333	99	SIORS	1065	6239	TAUT	76.60		224	10596	11749	5001	ICS VI	1691			155	Ę	ŝ	689	1187						_	12675		14570
	Press P		191	181	260.4		44	543	100		A NOT	8,000	10453	17761	1113			110.4	176.6	264.9	357.7	446	5.4.3	613.8	7100			878.7	1059.7	1236.4	1404.2	1589.6
	Materials P		Cubering of	Al Koki.TK			dence ited		0.1																							
			Т	VILL STORY		Cont.																										
	İ		g	<u>^</u>																												

60
Е.
at
<u>Ş</u>
Q
<u>.</u> 2
3
g
2

																														٦
Del-2 Wave-1 Wave-2 Slope-1 Slope-2											_																			
Slope-1		1																				_								
Z-aveW	87	1			₹.er	•																				-				
Wave-I	ę	ſ																			•									
2-12	87	2	1.6	1.6	1.6	1.6		2	1.6	1.6	0	0.	0.1	0.1	1.6	9.1	3.2	3.2	3.2	3.2	32	3.2	3.2	3.2	3.2	3.2	3.2	2.5	3.5	3.2
		5	1.6	1.6	1.6	91		0.1	1.6	1.6	1:0	1.0	1.6	1.0	1.6	1.6	3.2	32	3.2	3.2	32	3.2	3.2	32	32	3.2	3.2	3.2	3.2	3.2
Γ		Þ	3	62	3	ŝ	3 (70	3	3	3	3	62	3	62	3	3	62	8	3	3	62	62	3	62	62	3	5	62	62
3		k	5	8	3	5 9	5 (8	8	\$	\$	\$	\$	8	8	8	8	\$	\$	\$	\$	\$	8	\$	8	\$	8	8	8	8
53	X		3 %	1 2	1×	3 2	3	ล	ห	ม	ห	ห	ห	ห	ห	ห	ห	R	ห	ห	ห	ห	ห	ห	2	ង	ห	ุ่ม	ห	য়
- He	-	╋			à È	ì	3	5	E	LSI	2	E	2	23	5	12	53	52	5	12	52	2	E	ম	53	53	53	53	ম	221
and the second sec		_					_				• •			167	167	167	167	167	167	167	167	167	167	167	167	167	167	167	167	167
ļ											_						196.2			196.2		196.2	96.2	62	196.2	196.2	196.2	196.2	196.2	96.2
ļ			<u>R</u> 2				130.1	2	1962	196.2	81				1962									•						
	, E		C.155	24.15%		CC.1156	231.92	331.95	931.95	\$31.95	931.95	931.95	931.95	931.95	201.95	391.95	26.159	20.159	931.95	26,156	931.95	26.162	931.95	931.95	931.95	931.95	931.95	26,162	931.95	201.95
	-	-	3	8 8	R	R	8	8	2	8	8	8	8	8	8	ន	8	8	8	8	8	8	8	8	8	8	8	8	8	8
		-	<u>s</u> :	8 3	8	8	8	8	8	8	8	x	x	x	8	8	8	8	8	\$	2	x	x	x	8	2	2	8	x	26
	NHA 'TH	ke/mm2	-			_	_	-	-					. 0		0					, a	0	0						•	0
	3	g					_																4	. 00	2 04	2 00			9	8
	13	nm	72.	ม่	2	ล่	22	25	1 2		9	3	9	\$	ŝ	9	×	i X	1 ×	3 X			12	5	§ \$	35	9	8	8	50.8
	-	ပ		_	_									2 0		2 9	2 9	2 5	2 5	3 5	2 9	2 8	2 5	2 5	3 5	38	2 8	2 8	. 8	680
	Cond, h	W/m2K	1630	1780		199	8	185	3 5	28																				
	- L	kPa	87.8	180.9	274.1	522.9	280	140.7			174 0	9446		2746		2 8	4.0.0			9°C/7	110	L BYL		2 E		1.1.1		226	1665	56
	Materials P		Substrate	AI 6061-T6		Vapor	descripted		2	1 surface																				
		No. Reference	L	1990	Metal cost																									
	t	Ň	•												_															

																													_		ו
TDel.2 Wave-1 Wave-2 Slope-1 Slope-2																															
ope-1		t			_																										
we-ZI SI		ł	<u> </u>													_		-									-				1
mlr-	8							_																							4
Wave	m	+														<u>~</u>		~	~			10	10	+ 0	4 0	4 0	4 6	4 0	4 0	3.2	1
7-190			1.6	1.6	1.6	1.6	9.1	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	<u>е</u>	3			9 C		i .	5 e	ń.	ń.					
		-	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	3.2	3.2	3.2		4 6	4 C			10		70		3.2	32	ž
ſ	_		79	8	3	62	62	3	3	62	3	3	3	3	3	62	62	62	5	3 5	3 3	35	35	35	8	3 9	3 :	3	3	3 3	170
Ĕ	\$ 6	25	69	8	\$	\$	\$	\$	\$	\$	\$	\$	\$	8	\$	\$	\$	\$	3	5 9	6 3	8	6 9	6 9	5	\$	5	5	\$	\$ \$	3
		K UP		2	20	2	2	N.	2	~	2	<i>S</i>	Ŋ	2	S	2	X	X	<u>, x</u>	3 3	<u>a</u> ;	2	33	9 3	ล	ล	8	ม	ห	<u>ุ</u> ม	2
ŀ	2	Mayan K	57.																			_									
	9	W/mK	197	5	152	2	2	ম	127	E	ន៍	5	E	5	5	23	5	įĘ	ā š	ā	5	5	51 	5	2	ន	2	<u>ร</u>	2	8	52
I	-	Nex	6	167	167	167	167	167	167	5	161	167	167	167	167	167	163	577	6	0	167	167	167	167	167	167	167	167	167	167	167
ł			E	94.2	\$2	22	8,2	96.2	8,2	2 2	7 X	86.2	96.2	96.2	96.2	8,2			7.041	130.2	196.2	196.2	196.2	196.2	196.2	196.2	196.2	196.2	196.2	196.2	196.2
	H	MPa											- <u>-</u>) ¥	Y	2 4	2 3	6	2	<u>x</u>	8	8	<u>x</u>	8	8	8	8	8	8	2
	H.	MPa	<u>जा क</u>	20100							21.15V					20100		CA-104	CC.162	26.162	26.152	931.95	26.166	26.162	26.152	26.152	931.95	20.152	931.95	56.169	931.95
	C, BHN	/mm2]		8 8	3 8	3 8	3 8	3 8	3 8	8	R F	3 8	3 8	88	3 8	3 8	3 8	8	8	ล	ຊ	8	8	ន	8	8	8	8	8	8	8
	NTHe.	4	ł			0.7	0 7		2 7	<u> </u>	<u> </u>	2 3	2 8	2.8	2 8	R 8	R 2	<u> </u>	<u>x</u>	x	x	2	x	ĸ	8	8	x	8	8	8	8
	H NHR H	t-land		~ 9	~ •	~ ~								_																	
		_		14	171		171	171	14	171	22.4	92	47		9			127	127	127	127	127	127	127	25.4	25.4	25.4	25.4	1×	12	25.4
				141	171	127	127	121	127	127	2		2	92			3	127	127	127	127	127	127	127	25.4	25.4	25.4	254		12	25.4
	Ē	,		-					_																						-
			С К	1	8	8687	83	8	8	80	g	8	8	000		018	800	010	020	620		000	220	0422	0070	242	8	2200		2810	329
	1.22.1				•••	•••																									
			kPa	970 U	173.8	275.7	517.9	2612	1712	105.4	103.1	170.3	275.7	513-	280.9	167.7	ğ	100.	167	E			175		ľ	ŻĘ		į		2.27	114.1
	ſ		¥		Ŗ			8		8																					
		Materials		Substrate	Al 6061-T6		Vapor	deposited	 Z	2 Surface																					
	f		906																			_									
			Reference	Chung et al.	1990	Metal cont																									
			No.																									_		<u></u>	

															_						_								٦
Wave-I Wave-2 Slope-1 Slope-2																													
Slope-1							_																						
Vave-2	an Bu	:	.:=																										
I-me/	L B																												
		Ŀ	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	3.2	3.2	3.2	3.2	32	2 E	7 6	7	3.2	3.2	3.2	3.2	3.2	32
TDel-I TDel-2		6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	1.6	32	3.2	32	3.2	32	3.2	2	2	3.2	3.2	3.2	3.2	3.2	3.2
		E	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	61	19	61	19	19	19	19	61	5
Ę	0	6	\$	8	8	8	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	\$	8	\$	\$	8	\$	8	\$	\$	\$	\$	\$
E	X QPa																		8		_								
Ļ	_																						_					35.3	
5	E/mK		S.	35.3	35.	35	35										_	_	35.3	_					7 35.3	_			
			167	167	167	167	167	167	167	167	167	167	167	_					167									167	
			10.24	39.24	30.24	20.24	20 SA	20.24	10.05	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.2	3.6	39.24	39.2
ſ		ľ		201.05	21.95		20100		2010	26.159	26.150	26.166	26.166	26.150	26.156	231.95	26.156	26,129	20.159	26.166	20.152	26.162	26.166	931.95	20.159	201.95	26.166	931.95	<u> 931.95</u>
		Ξ		• •				• •				-					-	•	-	-	-	*	*	-	-	-	-	•	╡
	5 9 1																	×) ¥			Ŷ	2	x	x	X	2	2	8
	Ha, BHN H	kg/mm/2	K 8	кð	. 9	K č	κđ	ĸð	ĸð	ŇŎ	. 0											~ 							
		W	> <		•	> <	-	> <	> <			• •		• •	• •	• •	• •		• •		ð	0	0	• •	• •		• •	• •	٩
		B								2.0			2,5	2 5	25		ž				N X	25.4	89	2	3		25	8.95	50.8
		- U	1																										
	Cond, h	W/m2K	0/07	1980	M17		0252	2430		1810	0102	0112	10017							0000				1000				2 2 2	2420
	Press, P (108.9	1755	1.012	519.7	8	166.8	103.6	10.4		1.1.7		4.612	7.021	2.5		201	1.012	V.110	1462	10.1			+0/T	4.007			97.4
	Matenals P	X	Substrate	AI 6061-T6		Vapor	deposited	ę	L surface																				
	F	Reference	Chung et al. S		Metal coat	-		-											-			-							
	┠	No. R	۲ ۵	11	Ž																								
	.	_			-					_	-	-		_		_													

8
Ē
Ë
ö
C
<u>ಲ</u>
I
ä
ų
2

								_			_		_																	٦
Dei-1 Dei-2 Wave-1 Wave-2 Stope-1 Stope-4																														
Slope-1																														
Vave-2	En					-																			-					
I-ane		<u>.</u> 																							-					
<u> </u>	an	9'I	1.6	1.6	0.	0	1.0	1.0	1.6	1.6	1.6	0.1	0.1	91	9.1	3.2	3.2	3.2	3.2	3.2	3.2	3.2	32		1	3.2	3.2	3.2	3.2	3.2.1
i De	m	1.6	1.6	1.6	1.0	1.6	1.6	1.6	1.6	1.6	1.6	1.6	0	1.6	1.6	3.2	3.2	3.2	3.2	3.2	32		22		7.0	3.2	3.2	-32	3.2	3.2
	89	6	19	19	61	19	19	19	19	19	19	19	19	19	19	19	19	19	19	19	2	2	2	. ;	2	19	19	19	19	61
묊	OP.			8											9	8	8	8	5	9	. 9	5 9	. 9	5 5	3	\$	8	\$	\$	\$
R	OP.												_																	
ž	um/mK	67.	8	କ୍ଷ	8	<u>R</u>	8	8	8	8	8	8	8	8	8	74	×i		-									_		
. 9	W/mK	35.3	35.3	35.3	36.3	35.3	36.3	35.3	35.3	35.3	35.3	36.3	33.3	36.3	33.3	35.3	35.3	35.3	25.	2	35	25	3.5	8	333	33.3	ž			22
	μK		167	167	167	167	167	167	167	167	167	167	167	167	167	167	167	167	161	121			0) 1	167	167	167	167	167	167
	_	E	30.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	39.24	20.74	10.06	100		5.6	17.65	7.62	17.62	39.24	39.24	39.24	39.24	39.24	39.24
1 He	2			8	8	8	8	8	26.159	8	26.166	201.95	331.95	56.	8	8	8	3		2.2	2	2	56.1	26.166	931.95	26.169	931.95	26.154	31.95	56.166
				26.169	56.166	931.95	931.95	931.95	ŝ	26.169	8	2	2	83	8	8	5		2 2	R 8	<u> </u>	F	, 2	5	4	4	4			8
			• •	* 4	•		•						•		•				-	•		-								
	-		2 8	2 8	8	8	8	\$	8	2	5	8	8	8	8	\$	2 8	2 2	R 2	8	8	x	8	8	x	8	8	\$	2	8
ł	Ê.	Т		127			1		1.2								4 6	14	11	71	127	127	127	1.2	25.4	4 22	1 20			25.4
	2	Ę								3 7 						_									_					_
	=	g	1	121	4 <u>-</u>	4 5	121	4 : 		4 X	4 X		1×	3 ĕ	3 X 						2	я —	=	א 	· ~ ·		4 č	4 ē		1 4
	-	υ		0 0						2 9	2 9	2 9	2 9	2 5	2 3	R :	2	8	8	3	8	8	8	8		2 8	3 5	85	3 8	2800
	Cond, h	W/m2K		2120																										
	Press, P		6771	1703		1.716	81412	10/./	105.4		CC1	7087	1.410			1.88	100.4	166.8	273.9	517.9	280.9	169.4	105.4	105.4		Ì				1.01
		kPa		<u>م</u>					1 2														<u>.</u>							
	Materials		Substrate	VI 6061-TS		Vapor	deposited	£ .	2 surface																					
									-												_									
		Reference	Chung et a	198	Metal cost																						_			
		°,	ŀ						_																					

Wave-1 Wave-2 Slope-1 Slope-2 um . 1.6 11.6 11.6 11.6 11.6 11.6 11.6 ٩ Del-2 um 11.6 9.19 9 2 9 Del-1 Min 12.74 1274 1274 1274 1274 1274 1274 1274 12.74 1274 12.74 12.74 12.74 14.71 ы В \$ \$ \$ \$ \$ \$ \$ 888 32 3 \$ 2 \$ \$ 3 \$ \$ 2 2 3 \$ \$ \$ 3 3 30 Mary Mark 2 W/mK 3 ka W/mK чЧ 20.159 20.159 20.159 20.159 20.159 331.95 26.169 291.95 26,169 931.95 931.95 931.95 201.95 931.95 931.95 931.95 931.95 931.95 931.95 201.95 201.95 291.95 221.25 221.25 221.25 221.25 221.25 221.25 26.152 Ha, BHN Hc, BHN Ha kg/mm2 kg/mm2 MPa 00 0 0 0 000 0000000 0 b 9 = 9 u ٿ Cond, h W/m2K 7552 518 518 518 518 11755 777.4 510.9 11755 510.9 11755 53092 53092 53092 53092 53092 1105.4 1105.4 1105.5 277.4 280.9 277.5 277.4 280.9 277.5 2 Press, P kPa Substrate Al 6061-T6 Vapor deposited In 1 surface **Materials** Reference Chung et al. 1990 Metal cost No 0

																				_						_				٦	
Slope-2																												_			
Wave-1 Wave-2 Slope-1 Slope-2																															
Wave-2	g				·								_																		
Wave-1	g																									~	~	~	8		
Del-2	R	1.6	917	23		1.0	1.6		1.6	_			1.6									7.0			2 32			2 3.2		2 32	
Del-1		1.6	2.	2	91	1.6		1.6					1.6	1.6		32							32							1 32	
3H	GPa	1/21	12.74	1274	1274	12.74	1274	1274	1274	1274	12.74	1274	1274	1274	_						_	1274	_	0 127	69 12.7	9 1274	69 127			69 12.74	
ES	GPa	66	\$	8	8	\$	8	æ	8	\$	8	8	8		S	_						_		<u>1</u>		68	_				
Ř	um/mK	Ĩ	12	8	32.1	321					2					9				_	<u>8</u>			<u>8</u>					12		
re Fe	W/mK	6ii		29		23.9	23.9			,					2		_					1 29	7 23.9							_	
	W/mK	19	167	167	167	167	167	163											_	_	1 167		1 167								
ЧЦ	MPa	A RI	18.6	18.6	9.81	9.81	0.81			10.4			10.4					18.9	9.81	9.81	18.6	9.81	18.6								
ſ		ŀ	26.166	201.95	S61.95	No iso	No su	767104	CC-106	S1.54	C4.164		CC106	24.164	24.164	CC.1156	CX.156	931.95	931.95	291.95	931.95	26.159	20.195		ACT OF						12.012
	_		• •		• •	• •	4 7	-	-				- •	-		-	-		-	-	-	-		• •	• •	-1 7	-	-	-	4 🖛	1
	<u> </u>	7	<u>s 8</u>	2	2 8	2 2	<u>R 2</u>	<u> </u>	8	<u>x</u> :	8	<u>R</u> 1	23	8	8	8	8	x	x	8	\$	3	3	2 2	2 2	23	2 2	8 3	8 8	2 8	2
	Ť.	7000/3X	171		4		71	121	27	5.4	23.4	4	2	4.5	5.4	¥.5	127	127	12.7	23	101		1	1		1.2	2	2.4	25.4		1.4
	77	Į								_			25.4		_						11						22		222		1.4
		83					_			4			~				_	_													-
		2K C	0892		0000	1310	866	1180	066	4160	6100	5150	6300	9999	3680	986	0000	0000							2300	899	019	9999	9906		265
		W/m2K			Z15.7		4.02	1712	110.6	5.4	175.5	83	4	5.7	8.7	5.4	2.0	28	2 5	141	E	171	1.12	2	115	6.08	276.6	26.7	254.6	22	8.2
	Press, P	kPa	_		2	8	8	17	11	2	1	8	8	ิ 	16	1	-		- ¥	4	<u> </u>					آمر 		~			
	Materials			A 6061-T6		Vapor	deposited		2 auríace																						
		Reference	Ŀ	1990	Metal coat																			-							
	t	No																						_	-						

												I	I			E S			Wave-L	17-2ARA	Aave-1 Wave-2 Stope-1	
			ľ					HA BHNI HE BHNI HE	Je BHN	H	Hc								-	- Will		
		Materials					_	Curry of	tre/mm2	MPa	MPa	W/mK	W/mK		-	-		-	T			
°N N	No. Reference		_	-	-						8681	5.04	962	16.6	69	122	11.0					
ŀ	,	Substrate		1460	8	0.19					1 699	140.5	396	16.6	\$	21	0.17	52.0				
	Les la		245.8	1580	8	0.19	0.19		101761				200	166	8	125	0.17	220		-		
	1111	ADA1-TAS1	374.9	1900	8	0.19	0.19	<u></u>	191.845					166	\$	125	0.17	0.23				
	m		15.45	2060	8	0.19	0.19		191.539		101			221	3	125	0.29	0.32				
	Transcon			990	8	0.19	0.19		187.258		1831		<u> </u>	2 7 7	3	ĬŽ	02.0	0.32				
	Bullenn	vepor		2460	Ş	010	0.19		186.137		1808	2041	ĥ	881	5			5		****		
	Interface,	deposited	242		3 (185 525		1820	140.5	8	16.6	\$	2						
		Pure Cu	377.5	3680	8	0.1V	~1.9				1017	_	×	16.6	8	12	67.0	75.0				
			482.8	4210	8	0.19	0.19		112.001		101	_	3	166	3	125	3.2	2.8				
			100	act of	Ş	0.24	0.24		155.046		1761		Ŗ		\$ \$	1		9 0				
			0.041		3 5	200	100		154,638		1517	_		201	8	3	4 6	3				
				1007	B				164 424		1515	140.5	88	166	\$	21	3.5	07				
			Ŕ	2800	8	12.0	10							166	\$	125	3.2	2.8				
_			A17.6	2070	8	0.24	0.24		154.23		rici				; ;	301	35	23				
					5	0.74	0.24		153517		1506			201	6							
			1.161		3 (102.201		1496	3 140.5		16.6	3	9	0	2				
			248.4		8						1403	_		1666	\$	122	3.8	33				
			377.5	3110	8	17.0	170		741701		104 1			16.6	\$	125	3.8	e C				
			111	3660	8	120	0.24		151.968						9		015	0.17				
_			A 101	09/11	8	0.25	0.25		203.262		T 61	_			6 (0.17				
		Vapor			\$	Y C C	0.25		202.141		1961				5							
		deposited	57		8	33			ACC FRE		1075		_		\$		6.15	0.17				
		20	3775		8	2	3								\$		0.15	0.17			_	
			482.8		3	22.0	220		200.917						3		0.26	0.29				
			114.1		8	0.45	0.45		19.068			_			3		× •	0.0				
			E.	7840	3	0.45	0.45		192.864		1892				5 (
_					5	A A			192.151		1885				5							
					3 \$				101 R45		1882	2 140.5	~		5		8					
			3						144 679		1615	5 140.5			8		1.91	8.				
			149.2		-	_					1 440				\$		1.91	1.66				_
			2202		8				103.914						3		161	1.66				
			368.7	8	8	0.45	_		163.303						3		5	166				
			3		8	0.45	0.45		162.895		1596				5 \$							
						0.25			155.352		152		~		6							
			191				0.75		154,332		1514	4 140.5	~		5							
									143.005		1510		~		3		4.6	3.7				
			3715		_						1		~		\$		34	3.7				
			500.4	1 2810	8				TUCCT			1										

			ł	Ì	F			H	Нc	8	23	å	2							•
Materials P	Press, P			1					e	W/mK	<u>X</u> mX	um/mK	e e e	OP.	um .		nn l			
	-	W/m2K	с v	an	um k	ke/mm2 k	XC/TELEV	LIM	- YIMI		÷		ž		162.1	165.1	0	0	0.1.36	671 O
Ŧ				1111	0.075		1	1.6791	•	10			3 (1.53	1621	c	0	0.136	0.136
Substrate	8				5000	110		1079.1		167			8		100.1		• •	. 1	0.136	0.136
AI 6061-T6	1403	11-287						10/01		167	1.03		8		100.1	100.1	•	<u>.</u>		
	2104	315451		C/0.0	C/0.0					141	1.03		38		1.531	1.531	0	Š .	8.1.9	R
Outde met	2266	3225.81		0.075	0.075	110		1.07.1					9		1.531	1.531	•	0	0.136	
	STAC	4055.04	_	0.075	0.075	110		1.6701		101			3 9		1 5 31	1521	0	0	0.136	136
				2000	2000	110		1079.1		167		_	8						21.0	A 1 %
	3885	51.5205		2220				105		167			38		1.531	1601	>	>		
	1956	6172.84		0.075	0.075	011		1.2.01					9	-	1.531	1.531	•	0	0.136	0.130
		6177 BA	_	0.075	0.075	110		10001		101			3 8		153	1531	C	0	0.136	0.136
				2000	YW0	110		1079.1		167	7 I.03		8				•		71.0	A14
	STIG	S ON		c						147	7 1 2 2		38		1.531	1.531	0	>		
	61/15	8264.46		0.075	0.075	110		1.001		<u> </u>			9		1 531	1.531	•	0	0.136	0.136
		22 0100		2000	0.075	110		10001		101		_	8 9			153 1	c	C	0136	0.136
	28	00-1100						19701		167	7 1.03		8		1001		•	•		
	6798	16.0606		C(0)0	C/0.0	11						_	5		1.531	1.531	•	0	0.1.0	
	7554	100001		0.075	0.075	110		1.6791					3 9		1531	1531	0	•	0.136	0.136
				2000	2000	110		10001		10			8				•	¢	A126	0136
	2	1.00201						10001		167	7 1.03		8		1.531	1501	•	>		
	1028	19762.8		0.075	0.075	110		TAINT					66		1.531	1.531	•	•	0.136	0.130
	6649	1471.8		0.075	0.075	110		1.6401		2	_		3 9		1 531	1 531	•	0	0.136	0.136
		1 100.30		2000	2.00 B	110		1.001		167		-	8 9				Ċ	C	0136	0.136
		1.0000		2000	2000	110		10001		167	7 1.03		8		1601	1001	> <	> 0		174
	12221	ZATU		C/A.A						167			3		1.531	1.531	5	>	8.1.2	
	1295	21186.4		0.075	C/0.0	710							ş		1.531	1.531	•	•	0.136	0.136
	16731	33670		0.075	0.075	110		10/01					3 9		6199	6199	0	•	0.311	0.311
0		7467 60		5000	0.075	110		1.0701		167		3	8 8		410.0	017 7		•	1110	0.311
	1001	10000			2000			10001	-	167	57 1.03	<u> </u>	3		0.019	610.0		•		
	1360	6535.95		C10.0	C/0.0			1.0001		167			8		6.619	6.619	•	0	0.311	
	2374	9345.79		0.075	C/0.0	110							¥		6.619	6.619	•	0	0.311	
	2374	8695.65		0.075	0.075	110		1.4.01	-				3		6 K 10	6199	0	•	116.0	0.31
	2000	1 TANK R		0.075	0.075	110		1009.1		16		2	8 (10.2 2	6 610		C	0.311	16.0
		10740		5000	0005	110		1079.1		16	_	3	8		4100	10.0	•	• •		120
	CIRC	101701	_					10001		16	167 1.03	5	**		6.619	0.019	>	>	110.0	
	3665	17241.4		56.0									3		6.619	6.619	•	•	0.311	
	3231	16025.6		0.075	0.075	110		10/2-				2 0	3		6199	6.619	•	•	0.311	115.0
	5180	20266.6		0.075	0.075	110		1.001		ž		2	8 (2 410		•	0 311	10.0
		Lunc		007	0.075	110		1009.1		ă	_	2	8		0.017	410.0	> <			110
_		FIVE			_			1001		16	167 1.03	10	8		6.619	0.019	>	>		
	2032	20661.2				110						60	38		6.619	6.619	•	•	0.311	
	2005	34129.7		6.0.0								8	3		6.619	6.619	•	•	0.311	
	6666	11210.8		0.075		011		1.07.1		ii ;		3 8	3 9		6199	6.619	•	•	0.311	0.311
	2002	77482		2.00 G	0.075	110		66		-		2	8							

0.134 0.134 0.19 0.19 0.19 2222 •11 0.19 820.0 820.0 820.0 820.0 820.0 820.0 820.0 820.0 821.0 821.0 821.0 821.0 821.0 821.0 821.0 821.0 821.0 821.0 820.0 800.00 0.136 0.136 0.136 0.136 0.136 0.136 0.136 0.136 0.136 0.136 0.136 1.136 Ê Slope-0.18 0.038 0.038 0.038 0.18 0.18 0.18 0.132 0.13 0.13 0.18 0.132 0.132 0.13 0.13 0.028 0.028 0.028 0.028 0.028 261.19 0.311 0.028 0.311 0.311 116.0 110.0 0.311 116.0 0.311 Slope-I 0.311 11C.0 0.311 0.311 116.0 115.0 LIE:0 a 0 0 0 0 0 0 0 0 0 0 0 Vave-2 8 000 00 0 0 00 00 0 0 0 00 00 0 0 00 Wave-1 000 0 83 1.531 1.5511 Del-2 2 8 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 6.619 Ş З С Б 3333333 Ra OPa Bc um/mK kc W/mK 167 167 167 167 \$ [6] [6] 191 191 191 191 k W/BK 3511.96 3511.96 3511.96 3511.96 3511.96 3511.96 3511.96 3511.98 3511.98 3511.98 3511.98 3511.98 3511.98 3511.98 3511.98 3511.96 3511.96 3611.96 3611.96 3611.96 3611.96 3511.96 3511.96 3511.96 Hc MPa 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 667.7 667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1667.7 1.2701 1.2001 1. E Ha, BHN | Hc, BHN | kg/mm2 0.100 5 5 BILD 0.075 0.075 0.075 0.075 0.075 0.075 0.075 0.075 0.075 0.075 0.075 0.075 0.075 0 12 § 19230.8 37732.4 37732.4 37732.4 37732.4 2035.6 20505.1 2014.13 2014.13 2014.13 2014.13 2014.14 2015.14 2014.14 2015.14 2014.14 2314.81 4545.45 4545.45 7462.69 8130.06 8130.06 11387.9 11387.9 11387.3 116207.5 116207.5 18450.2 18450.2 25773.2 Cond, h W/m2K 4532 4802 6151 6798 2719 2719 2719 2704 2704 Press, P kPa Substrate Mild Steel, EN3B Oxide cost Substrate Mild Stool, EN3B Oxide cost Substrate Al 6061-T6 Oxide coat Series C Materials Al-Astrabadi et al., 1980 Mian et al., 1979 No. | Reference YIP, 1974 Cont.

$ \begin{array}{c c c c c c c c c c c c c c c c c c c $								Ī				Ч.		2	3	E I		Del-I D	Del-2 W	Wave-1 Wave-2 Slope-1 Slope-2	ave-2 Slo	pe-1 Sk	be-2
Number Number<	E.	Γ			Cond, h	B	t1		NHA PH		2 9	N.	WimK	W/mK	Xe/en		-	-	-	2			
Numerical baseding Total Total <th></th> <th></th> <th></th> <th></th> <th>W/m2X</th> <th></th> <th>-</th> <th>1</th> <th></th> <th></th> <th></th> <th></th> <th></th> <th>EOI</th> <th></th> <th>88</th> <th></th> <th>_</th> <th></th> <th></th> <th></th> <th></th> <th></th>					W/m2X		-	1						EOI		88		_					
Allower: Tay Tay <thtay< th=""> <th< td=""><th></th><td>Peterson &</td><td>Substrate</td><td>1.144</td><td>58.76</td><td>2</td><td>19</td><td>5</td><td>83</td><td> </td><td>NO FEE</td><td></td><td>2</td><td>1.03</td><td></td><td>8</td><td></td><td>3.607</td><td></td><td></td><td></td><td></td><td>741.0</td></th<></thtay<>		Peterson &	Substrate	1.144	58.76	2	19	5	83		NO FEE		2	1.03		8		3.607					741.0
Monoline First			A1 6061-T6	763.5	73.43	ห	61	•	8		20104		2	1 0		38		3.607	1.87	1880	_		741.1
Anochast Takit sss T <tht< th=""> T T <</tht<>		1000		948.1	81.89	ห	61	•	8		C67166			e e		5		3.607	4.877	0.884			0.192
			Same Land	13/41	2.2	22	61	•	x		CC.162			3		3		3.607	4.877	0.884	1.016		0.192
				10041	1158	22	61	•	x		931.95		2	3 5		3 9		3 607	4.877	0.884	1.016	122.0	0.192
	-		Conting			1 ×	5	G	8		26.152		641			8 9		207 6	1.0	0.884	1.016	0.224	0.192
				218		3 8	5 3	• •	8		201.95		2			8				100.0	1016		0.192
	_			3344.7	214.1		5		2.2		A 100		21			8		3.607	1.8.4	100.0	010.1		
				5267.2	324.9		61	•	R		CA-164					9		3.607	1.871	0.884	1.016		0.192
	_			2 400	1000		61	•	8		56.166					3 9		2600	1871	0.884	1.016	0.224	0.192
	_			52.65				•	8		26.169		2			8				100	9101	_	0.192
				8769.9			53	•	8		201.05		5			8		100.5	10				0100
692.8 23 691.9 173 173 174 100<	-			10508	E165		5	-					2	_		8		3.607	119	0,864	010.1	5.5	
Ran San San <th></th> <td></td> <td></td> <td>18221</td> <td>692.8</td> <td>ม</td> <td>5</td> <td>•</td> <td>8</td> <td></td> <td>CK-156</td> <td></td> <td></td> <td></td> <td></td> <td>g</td> <td></td> <td>3.099</td> <td>1.87</td> <td>1.334</td> <td>1.016</td> <td>0.205</td> <td>0.192</td>				18221	692.8	ม	5	•	8		CK-156					g		3.099	1.87	1.334	1.016	0.205	0.192
					11.65	X	78.74	•	8		26.156		5			3 9		2000	A RTT	1.334	1.016	0.205	0.192
	_				į			C	2		931.95		641			8 :				1 374	1 016	0 205	0.192
82.05 25 78,74 95 91,95 179 1.00 95,05 182.11 25 78,74 9 91,95 179 1.00 96 3099 205.11 25 78,74 9 931,95 179 1.00 96 3099 205.11 25 78,74 9 931,95 179 1.00 96 3099 205.12 27 78,74 9 931,95 179 1.00 96 3099 205.13 25 78,74 9 931,95 179 1.00 96 3099 391.6 25 78,74 9 931,95 179 1.00 96 3099 391.6 25 78,74 9 931,95 179 1.00 96 3099 3099 391.6 25 78,74 9 931,95 179 1.00 96 3099 3099 391.6 25 78,74 179 1.00 96 3099 3099 391.6 26 9 9				131.4					ð		21.25	_	2			3	_	2.00	10				510
95.77 22 77.4 9 991.95 179 1.00 56 3.009 192.1 22 78.4 9 991.95 179 1.00 56 3.009 255.1 23 78.4 9 991.95 179 1.00 56 3.009 315.1 23 78.4 9 991.95 179 1.00 56 3.099 315.1 23 78.4 9 991.95 179 1.00 56 3.099 315.1 23 78.74 0 931.95 179 1.00 56 3.099 315.1 23 78.74 0 931.95 179 1.00 56 3.099 559.3 22 78.74 0 931.95 179 1.00 56 3.099 559.4 170 1.00 95 179 1.00 56 3.099 78.45 22 78.44 1.00 95 179 1.00 5.34 78.45 22 78.44 1.00 95 931				566				.	21				2			8		3.099	1.8.4	1.334	1.010	CM.9	
1921 22 78.4 0 53 23.55 179 1.00 50 3.00 2551 22 78.4 0 53 23.55 179 1.00 50 3.00 2551 22 78.4 0 53 23.55 179 1.00 50 3.00 3151 22 78.4 0 53 23.55 179 1.00 50 3.00 3151 22 78.4 0 53 23.55 179 1.00 50 3.00	_			1229.3				•	ድ		CC-164					89		3.099	4.877	1.334	1.016	C02.0	0.194
ZX: ZX: <thz:< th=""> <thz:< th=""> <thz:< th=""></thz:<></thz:<></thz:<>	-			1604 3		25	1 78.74	õ	<u> </u>		CK.152				_	3		3 000	4.877	HEE'L	1.016	0.205	0.192
25.11 25 73.15 25 73.15 17 10.0 93 315.1 25 77.4 9 93 9			_					0	8		26.169		175	_		8			E.	334	1 016	0.205	0.192
3151 25 73 17 1.0 2000 3151 25 73 11 1.0 2000 2000 3151 25 73 11 1.0 2000 2000 5393 25 73 11 1.0 2000 2000 5933 25 73 11 1.0 2000 2000 5933 25 73 11 1.0 2000 2000 7645 25 73 11 1.0 2000 2000 7645 25 73 11 110 100 2000 2000 7645 25 73 11 11 11 110 2000	_			305/.4				• •	8		201.95		<u> </u>	_		8		3.00				200.0	510
315.1 23 78.44 9				3458.8		ล 	1.81	-	23				Ķ	_		8		3.099	18.4	1.34	010.1	CN7.0	1.1.1
3916 27,73 78,74 0 93,95 7779 22,87 78,74 0 93,195 78,64.5 22,87 78,74 0 93,195 78,64.5 22,87 78,74 0 93,195 78,66 0 93,195 1179 103 78,66 0 93,195 1179 103 78,66 0 93,195 1179 103 78,66 0 93,195 1179 103 78,66 0 93,195 1179 103 78,66 0 93,195 1179 103 78,66 0 93,195 1179 103 78,65 0 93,195 179 103 78,65 0 93,195 179 103 78,65 0 93,195 179 103 78,11 103 103 103 103 78,11 1175 1179 103 103 78,11 118 103 93,195 179				1912		8	18.74	•	<u> </u>		22156							3.099	4.877	1.334	1.016	0.205	0.192
773 22 73.9 23.93 173 100 53.4 644.5 22 73.74 0 931.95 1179 100 53.4 78.6 22 73.74 0 931.95 1179 100 53.4 78.6 23 85.6 0 931.95 1179 100 53.4 78.6 0 95 931.95 1179 100 66 5.334 78.6 0 95 931.95 1179 100 66 5.334 1775 22 85.6 0 95 931.95 1179 100 66 5.334 1775 22 85.6 0 95 931.95 179 100 66 5.334 1775 22 85.6 0 931.95 179 100 66 5.334 216.6 23 <th></th> <td></td> <td></td> <td>60527</td> <td></td> <td></td> <td></td> <td>•</td> <td>20</td> <td></td> <td>931.92</td> <td>~</td> <td></td> <td></td> <td></td> <td>3 9</td> <td></td> <td>3 000</td> <td>4.877</td> <td>1.334</td> <td>1.016</td> <td>0.205</td> <td>0.192</td>				60527				•	20		931.92	~				3 9		3 000	4.877	1.334	1.016	0.205	0.192
539.3 2 73.74 0 93.95 179 1.00 644.5 2 78.74 0 93.95 179 1.00 78.6 2 85.6 0 93.95 179 1.00 94.6 2 85.6 0 93.95 179 1.00 94.6 2 85.6 0 93.95 179 1.00 173.4 2 85.6 0 93.95 179 1.00 173.4 2 85.6 0 93.95 179 1.00 66.6 5.334 173.4 2 85.6 0 93.95 179 1.00 66.6 5.334 2 2 85.6 0 93.95 179 1.00 66.6 5.334 2 16.6 85.6 0 93.195 179 1.00 66.6 5.334 2 16.6 93.195 179 1.00 66.6 5.334 2 16.6 93.195 179 1.00 66.6 5.334				87173				•	<u> </u>		16.166	~				3 9		3 000	4 877	1.334	1.016	0.205	0.192
73.64.5 27.3 73.15 <t< td=""><th></th><td></td><td></td><td></td><td></td><td></td><td></td><td>•</td><td>20</td><td></td><td>201.02</td><td>~</td><td>21</td><td></td><td></td><td>8 (</td><td></td><td>000 0</td><td>1.81</td><td>1 22</td><td>1.016</td><td>0.205</td><td>0.192</td></t<>								•	20		201.02	~	21			8 (000 0	1.81	1 22	1.016	0.205	0.192
78.6 2 85.6 91.95 179 1.03 5.34 78.6 2 85.6 9 91.95 179 1.03 5.34 78.6 2 85.6 9 931.95 177 1.03 5.34 78.6 0 95.3 931.95 177 1.03 6 5.34 78.6 0 95.3 931.95 1.77 1.03 6 5.34 78.6 0 95.8 931.95 1.77 1.03 6 5.34 78.6 0 95.8 931.95 1.77 1.03 6 5.34 78.6 0 95.8 931.95 1.77 1.03 6 5.34 78.6 0 95.8 931.95 1.77 1.03 6 5.34 78.6 0 931.95 1.79 1.03 6 5.34 78.6 0 931.95 1.79 1.03 6 5.34 78.7 1.81 1.93 1.93 1.93 5.34 78.7						_		-	2		931.94	5	5			8					1015	0 748	0 1 02
7.24 2.34 7.45 2.5	_			1773				_	2		21.0	~	5	_	3	8		2.334	1/8.4	0.000	010.1		
346 22 846 2 856 9 951 9 1727 22 856 9 931 9 17	_			5.01-0				-	R 1			<u> </u>				38		5.334	1.87	0.889	1.016	0.448	741.0
1227 22 85.6 9 931.85 179 100 5.34 174.5 22 85.6 9 931.85 179 100 5.34 236.6 23 85.6 9 931.85 179 100 5.34 275.8 25 85.6 9 931.85 179 100 5.34 375.8 22 85.6 9 931.85 179 100 5.334 375.8 23 85.6 9 931.85 179 100 6 5.334 375.8 25 931.85 179 100 6 5.334 375.8 25 931.85 179 100 6 5.334 375.8 25 179 100 6 5.334 911.6 9 931.85 179 100 6 5.334 911.8 100 95 931.85 179 100 6 5.334 911.8 103 931.85 179 103 931.85 179 9.336.65 <t< td=""><th>_</th><td></td><td></td><td>965.7</td><td></td><td></td><td></td><td>•</td><td><u> </u></td><td></td><td>X-164</td><td></td><td></td><td></td><td></td><td>5</td><td></td><td>5.334</td><td>4.877</td><td>0.889</td><td>1.016</td><td>0.248</td><td>0.192</td></t<>	_			965.7				•	<u> </u>		X-164					5		5.334	4.877	0.889	1.016	0.248	0.192
173.4 22 65.6 9 931.95 17.9 100 6 5.34 174.5 22 85.6 0 931.95 17.9 100 6 5.34 275.6 22 85.6 0 931.95 17.9 100 6 5.34 275.6 22 85.6 0 931.95 17.9 100 6 5.34 375.8 22 85.6 0 931.95 17.9 100 6 5.34 375.8 23 85.6 0 931.95 17.9 100 6 5.334 375.8 25 85.6 0 931.95 17.9 100 6 5.334 375.8 25 85.6 0 931.95 17.9 1.00 6 5.334 54.16 18.1 0 931.95 17.9 1.00 6 5.334 55.34 931.95 17.9 1.00 6 6 5.334 55.34 131.95 1.95 1.95 1.95 5.334				1430.9				•	<u>x</u>		931.9		<u> </u>			3		5.34	4.877	0.889	1.016	0.248	0.192
1745 22 856 9 93135 2166 25 856 9 93135 2396 25 856 9 93135 2365 25 856 9 93135 2365 25 856 9 93135 2365 25 93135 173 1.03 454.3 25 856 9 93135 538 25 83195 173 1.03 5416 25 93135 173 1.03 5418 25 93135 173 1.03 5.34 5416 26 93135 173 1.03 5.34 5418 25 93135 173 1.03 5.34 5418 25 93135 173 1.03 5.34 55.34 93135 173 1.03 5.34 66 55 93135 173 1.03 5.34 67.34 93135 173 1.03 5.34 9355 25 93135 <t< td=""><th></th><td></td><td><u>.</u></td><td>1597.</td><td></td><td></td><td></td><td>•</td><td></td><td></td><td>4.164</td><td></td><td>2 9</td><td></td><td></td><td>. 4</td><td></td><td>5 334</td><td>4.877</td><td>0.889</td><td>1.016</td><td>0.248</td><td>0.192</td></t<>			<u>.</u>	1597.				•			4.164		2 9			. 4		5 334	4.877	0.889	1.016	0.248	0.192
2166 28 856 0 931.95 11.9 100 2395.6 28 85.6 0 951.95 11.9 100 2395.8 28 85.6 0 951.95 11.9 100 375.8 28 85.6 0 951.95 11.9 100 5847 28 85.6 0 951.95 11.9 100 5847 28 85.6 0 951.95 11.9 100 5847 28 85.6 0 951.95 11.9 100 66.9 5847 28 28.1181 0 951.95 11.9 1.00 66.9 5.334 611.6 28 931.95 11.9 1.00 66.9 5.334 5.334 6.11.6 28 931.95 11.9 1.00 66.9 5.334 9.35.5 11.81 0 931.95 1.19 1.00 66.9 6.11.6 28 931.95 1.19 1.00 66.9 5.334 9.35.5 11.81				2563				•	<u> </u>		6.169					3 9		12.5	181	0,849	1.016	0.248	0.192
239.65 25 85.6 0 95 931.95 179 1.05 375.8 25 85.6 0 95 931.95 179 1.05 5.334 454.5 25 85.6 0 95 931.95 179 1.05 5.334 454.5 25 85.6 0 95 931.95 179 1.05 5.334 454.5 25 85.6 0 95 931.95 179 1.05 6.13 5.334 454.5 25 85.6 0 95 931.95 179 1.05 6.53 5.334 54.5 25 931.95 179 1.06 6.6 5.334 611.6 25 931.95 179 1.06 6.6 5.334 931.95 1193 1.07 1.06 6.6 6.6 5.334 93.65 25 931.95 1.19 1.06 6.6 5.334 93.65 25 1.19 1.06 6.6 5.334 93.65 25 1.19				2226	_			•			931.9	2	1		5	B			E.o.	000	1016	0.248	0.192
3758 25 85.6 9 951.95 179 1.05 5.34 375.8 25 85.6 9 951.95 179 1.05 5.34 454.3 25 85.6 9 951.95 179 1.05 5.334 538.7 25 85.6 9 951.95 179 1.05 5.334 518.6 9 951.95 177 1.05 66 5.334 54.85 25 181 9 931.95 177 1.05 5.334 54.85 25 1181 9 931.95 177 1.05 6.6 5.334 55.34 931.95 177 1.05 6.6 6 5.334 56.79 25 1181 9 931.95 1.179 1.06 6.6 5.334 93.85 25 1181 9 931.95 1.179 1.06 6.6 5.334 93.85 25 1181 9 931.95 1.179 1.06 6.6 5.334 11.84 9									2		6.166	<u>x</u>	1	_	3	8					1 016	A 7AR	0.192
5/35 25 85 931.95 179 1.00 5.334 5/41 25 85.6 9 931.95 179 1.00 5.334 5/16 25 85.6 9 931.95 179 1.00 66 5.334 5/16 25 85.6 9 931.95 179 1.00 66 5.334 5/16 25 931.95 179 1.00 66 5.334 5/17 1181 0 951.95 179 1.00 66 5.334 5/18 25 1181 0 951.95 179 1.00 66 5.334 60.0 95 931.95 179 1.00 66 5.334 931.95 119 1.00 66 66 3.3663 931.95 119 1.00 66 5.334 3.663 93.65 25 119 1.00 66 3.3663 93.65 25 1.19 1.00 66 3.3663 93.65 1.19 1.00											931.9	<u>v</u>	1	_	3	38		2	10.	0.00	010.1	040 0	610
538.7 25 53.9 73.9 179 1.00 5.34 538.7 25 85.6 9 931.95 179 1.00 66 5.334 538.7 25 85.6 9 931.95 179 1.00 66 5.334 54.16 25 1881 0 931.95 179 1.00 66 5.334 54.16 9 931.95 179 1.00 66 5.334 54.18 25 1181 0 931.95 179 1.00 66 5.334 54.18 0 931.95 179 1.00 66 5.346 933.55 25 1181 0 931.95 179 1.00 66 5.346 933.55 25 1181 0 931.95 1.179 1.00 66 3.3663 93.65 25 1181 0 931.95 1.179 1.00 66 3.3663 93.65 25 1181 0 931.95 1.179 1.03 5.663 3.663											015	Y	5		3	38		5.33	119.4	0.867	1.010		
2367 25 85.6 0 53.4 611.6 25 85.6 0 53.15 611.6 25 85.6 0 53.15 54.5 25 118.1 0 53 54.5 25 118.1 0 53 65.7% 25 118.1 0 53 65.7% 25 118.1 0 53 65.7% 25 118.1 0 53 65.7% 25 118.1 0 53 65.7% 25 118.1 0 53 73.653 25 118.1 0 53 73.653 25 118.1 0 56 73.653 25 118.1 0 56 73.653 25 118.1 0 56 73.653 119.1 1.03 56 73.653 1177 1.03 56 73.653 118.1 0 55 73.653 119.1 1.03 73.653 177 1.03 73.653 177 1.03 73.653 177 1.03 73.653 177 1.03 73.653				12166								y y			3	38		5.33	F8 4	0.889	1.016	0.243	741.9
611.6 22 85.6 0 93 931.95 179 1.03 54.58 22 118.1 0 93 931.95 179 1.03 54.58 25 118.1 0 93 931.95 179 1.03 65.79 25 118.1 0 93 931.95 1.79 1.03 69.95 25 118.1 0 93 931.95 1.79 1.03 69.95 25 118.1 0 93 931.95 1.79 1.03 93.195 1177 1.03 66 3.663 3.663 93.195 1179 1.03 66 3.663 93.195 1179 1.03 66 3.663 110.3 25 118.1 0 93 3.663 110.3 25 118.1 1.03 66 3.663 110.3 25 118.1 1.03 66 3.663 110.3 25 1.181 1.03 66 3.663 110.3 25 1.181 1.03 66 3.663 110.3 25 1.181 1.03 66 3.663 110.3 1.04				1991			_	-	K .			2 1	i		č	99		5334	118.4	0.889	1.016	0.248	0.172
54.58 25 118.1 0 95 931.95 179 1.00 65.79 25 118.1 0 95 931.95 179 1.00 66 69.95 25 118.1 0 95 931.95 179 1.00 66 931.95 1179 1.00 66 3.663 932.65 25 118.1 0 931.95 179 1.00 933.65 25 118.1 0 931.95 179 1.00 933.65 25 118.1 0 931.95 1.79 1.00 110.3 25 118.1 0 931.95 1.79 1.00 110.3 25 118.1 0 931.95 1.79 1.00 110.3 25 118.1 0 931.95 1.79 1.00 110.3 25 118.1 0 931.95 1.79 1.00 110.3 25 118.1 0 95 931.95 1134.4 25 118.1 0 96 1234.5 1.79 1.00 66 3.663				1228					5 '		2154	6			2 5	. 9		1683	4.877	0.762	1.016	0.242	0.192
65.79 25 118.1 0 951.95 931.95 179 1.00 66 3.663 69.95 25 118.1 0 95 931.95 179 1.00 66 3.663 93.55 25 118.1 0 95 931.95 179 1.00 66 3.663 93.55 25 118.1 0 951.95 179 1.00 66 3.663 110.3 25 118.1 0 931.95 179 1.00 66 3.663 110.3 25 118.1 0 931.95 1.79 1.00 66 3.663 110.3 25 118.1 0 931.95 1.79 1.00 66 3.663 1134.4 25 118.1 0 931.95 1.79 1.00 66 3.663				474				_		~	931.5	R 1			2 9			2.62	1811	0.762	1.016	0.242	0.192
69.95 25 118.1 0 95 931.95 1179 1.03 96 3.663 93.26 931.95 1179 1.03 96 931.95 1179 1.03 96 3.663 93.25 118.1 0 95 931.95 1179 1.03 66 3.663 110.3 25 1181 0 951.95 1179 1.03 66 3.663 110.3 25 1181 0 951.95 131.95 1.03 66 3.663 110.3 25 1181 0 951.95 131.95 1.03 66 3.663				1							931.9	<u>x</u>			5	8 3				CYL V	1 016	0.242	0.192
93.26 25 118.1 0 95 931.95 179 1.03 66 3.063 110.3 25 118.1 0 951.95 179 1.03 66 3.663 110.3 25 118.1 0 951.95 179 1.03 66 3.663 134.4 25 118.1 0 951.95 179 1.03 66 3.663				3					_	2	931.9	<u>x</u>	i	_	23	8				0.760	9101	0.747	0.192
73.26 110.3 25 118.1 0 95 931.95 179 1.03 66 3.663 134.4 25 118.1 0 951.95 179 1.03 66 3.663											931.9	x			33	3		1.00	119.4	40/ · A	714	C10.0	
											2	X			3	3		3.683	118.4	0.762	1.010	757.0	
				E								X		_	2	3		3.683	4.877	0.762	1.016	0.242	7/10
				2668.			_		×		2014		1										

																		_									_				-		~	~	2	2	5	2	2	2	2	2	1
ope-2	261.0	241.0	0.192	0.192	0.192	0.192	0.192	010		741.0	0.192	0.192	0.192	0.192	0.192	0.192	0.192	0.192	0.192	0100	610				_		_		_			_				_	1 0.192			0.192	0.192	0.192	
Wave-1 Wave-2 Slope-1 Slope-	242.0	0.242	0.242	0.242	0.238	0.238	0.238	910	0.4.9	867.0	0.238	0.238	0.238	0.238	0.238	0.238	0.238	200 0	0000		C(0)0	(A).	0.095	6.0	0.00	0.095	0.095	0.095					0.081		0.061	0.081	0.081	0.081	0.081	0.081			1
ave-2 SI	1.016	1.016	016	1.016	1.016	1.016	1 016		1.010	1.016	1.016	1.016	1.016	1.016	1.016	9101	1 016		9101	210.1	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016	1.016					
we-I Wav	129/	0.762	_			000	0550		0.559	0.559	0.559	0.559	0.559	0 550	0 \$ \$ 0	000					0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0.254	0 254	2.0	0.74	0.254	0.254	0.254	
	Ē				_			_	5	118	-	Ę	1.0	1.0.1			1/9.	1.0.1	Es.	118.4	4.877	1.87	4.877	4.877	4.877	1.877	4.877	4.877	4.877	4.877	4.877	4.877	187	181	1871	4 877	1 011				E		10.4
F	1.080 L	•	• •	÷ -	2005	• •		• 	267	267	267	257	1	8		à	197	1.92.4	0.457	0.457	0.457	0.457	0.457	0.457	0.457	2240	127	1477	120	0.457	202	Yor o	Y SOL	Y NO C	No. o								
I-IPG1	I C	Ř					+ ·	-	+	-									_	_																							
33	e do	3 32	8	99	8	3	38	88	9	3 9	8 9	8 3	8	8	8	38	88	88	3	38	3	ą	3 3	3 9	8 9	8 9	8 9	8 9	8 9	8 9	8 9	8 9	8 9	8 9	8 3	8 3	8	8	8	8	8	8	3
E	9		-			_					_														_						·												·
3				_		-				<u> </u>	9	0	3	5	33	1.03	1.03	5	63	W			1.03	5.1	5.1	50.	5.	8	1.03	5	63	5	8.	63-1	1.03	1.03	1.03	1.03	1.63	1.03	1.03	1.03	1.03
9		1.03		1.03	1.03	1.03	1.03					_			9 1.03																	2	2	2	2	2	2	621	13	2	13	179	2
	81		1	6.1	51	2	2			21	5	2	6	61	61	2	2					-		-		-		-			_												
	MPa																																									2	
f		56.150	C4.164	20100	2011CK		20102	64.16	331.95	26.169	231.95	26.125	201 95	20100	20100	No in	26.164	CC.1CK	5.152	CC.166	26.156	931.95	931.95	931.95	931.95	931.95	26.166	931.95	931.95	931.95	331.95	931.95	391.95	26,169	591.95	931.95	26,159	01.05	20,179	26.159	56.169	931.95	20100 30 100
	A Ha	L						_																																			
	Hc, BHN ke/mm2			•											<u> </u>	<u>s</u> :	22	8	2	<u>x</u>	8	8	8	8	8	8	8	28	3	2	2 8	8	28	8	2	2 8	2 8	2 8	2 8	2 8	2 8	2 8	R
	Ha, BHN Hc, BHN Le/mm2 ke/mm2	ĥ	83	ይ ነ	ድ ያ	ድ	8	z :	2.	6	2 8	2 2	× 6	83		~ ·	~ ~	~	<u> </u>																								
			•	•	0	•	•	0	C	• •		5 (0	0	0	0	•	•	0	•	0	¢	• •			• •															-		20
		Ē	118.1	118.1	118.1	118.1	120.6	120.6	2001	0.01	0.021	120.6	120.6	120.6	120.6	120.6	120.6	120.6	120.6	1577	157.7	1.1.1	1.101					1.1.51	1.161					1020		163.6	1029						163.8
	L	1	R		ม	ม	2	č	3 2	9	2	ห	ห	ม	ห	ห	2	25	12	Ň	3 %	3 2	95	3 2	93	23	3	ลเ	2												_		2
		W/m2K (263.4	323.6	413.7	455.8	27.45	8	R 7	1.1	11.68	104.6	130.7	160.2	214	270.7	326.5	1002	1.10	No. C			5.64	4776	109.2	1.961	163.9	205.1	28	288.1	39.4	383.6	55.14	68.71	14.52	83.53	98.62	114.81	133.1	167.4	2013	236.8	265.5
		-		_	10526	00021	1.00			81126	67121	1790.9	2607.3	1502.7	5223	7014.2	0 0 % 0		0/01	33	6	3	921.8	1185.1	1738.2	2616.1	3467.6	5276	5207	8778.7	19482	66771	403.8	735	965.7	1255.4	1790.9	2695.1	3520.3	52233	7005.4	8752.4	10429
	Press, P	kPa					1 ×	41	F	ъ 	21	5	36					5								<u>a</u>				ي. 													
	Materials		Substrate	T-TOND T	Parilan A		finneo.																																				
	Γ			<u> </u>		<u>< (</u>	<u>ر</u>																										-										
	No. 1 Beference		Peternon e	Fletcher,	0661		Cont.																																				
	_ 	ia i	-	-									_	_	_	_		-			_																						